



The Photo Injector Test Facility at DESY in Zeuthen

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for the PITZ collaboration

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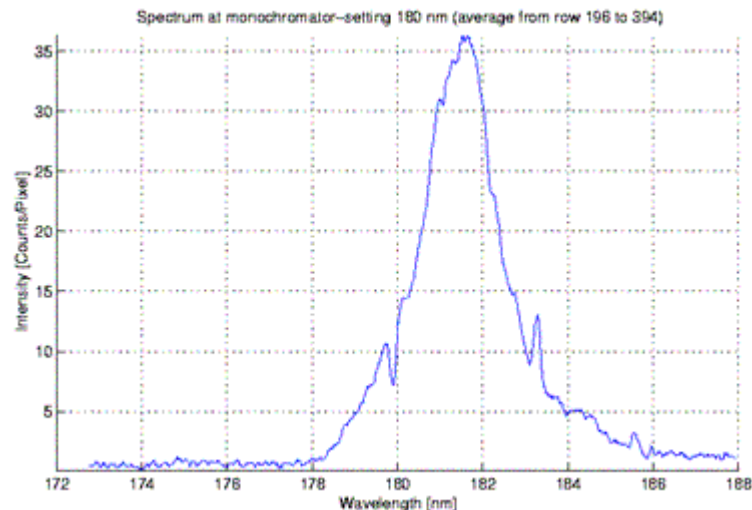
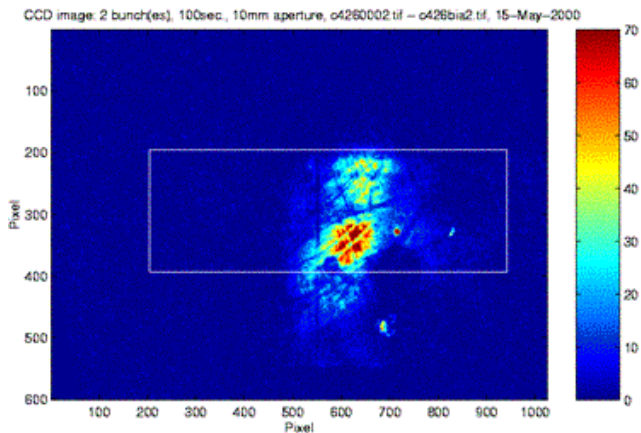


Overview

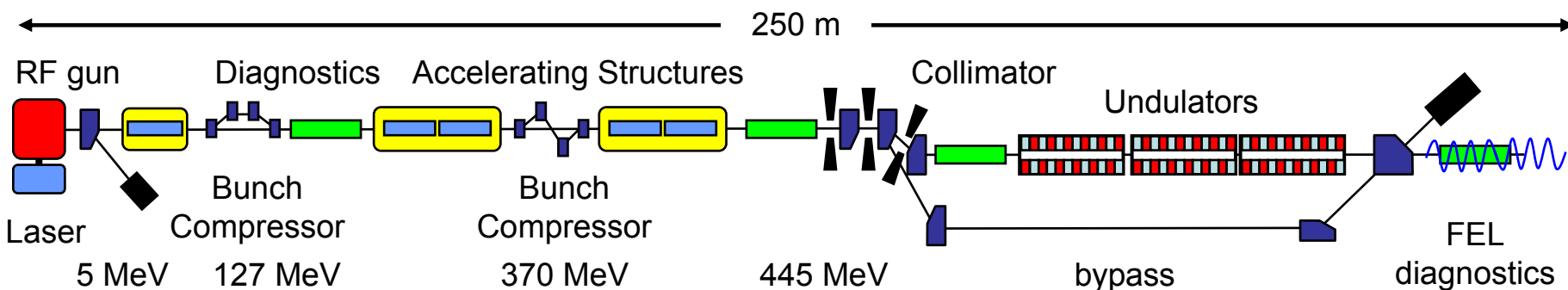


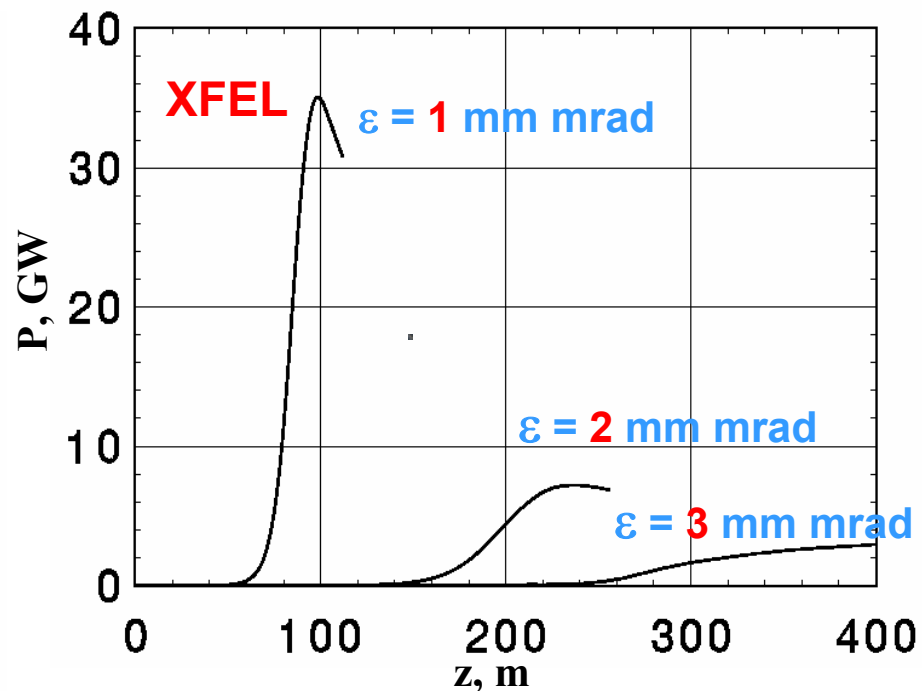
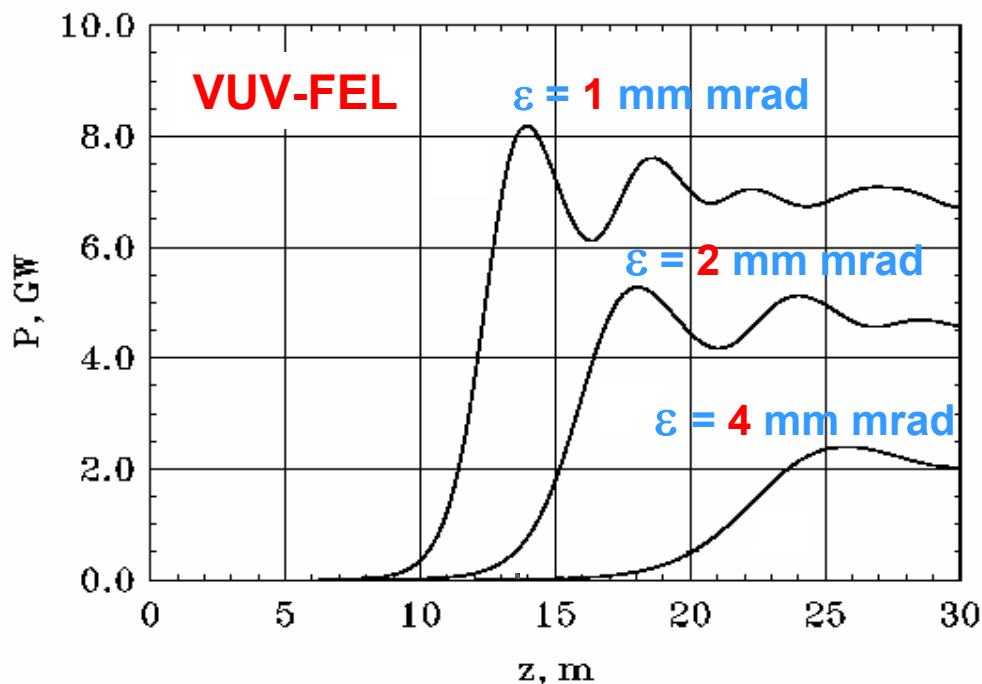
- **Motivation: VUV-FEL and XFEL**
→ photo injector R&D for DESY's FELs
- **The photo injector at Zeuthen**
→ a brief history of PITZ
- **The PITZ1 research program**
→ presentation of the PITZ1 results
- **Facility upgrade: towards PITZ2**
→ current status and future plans
- **Summary**

- **TTF1** has reached SASE in 2000



- **VUV-FEL** is running as user facility since August 2005





- performance of the planned **XFEL** (>2012) depends strongly on the electron beam quality of the **injector**
- beam quality can only **deteriorate** in the accelerator
- electron source must provide **very small emittance** beam
- photo injector development is **urgent**



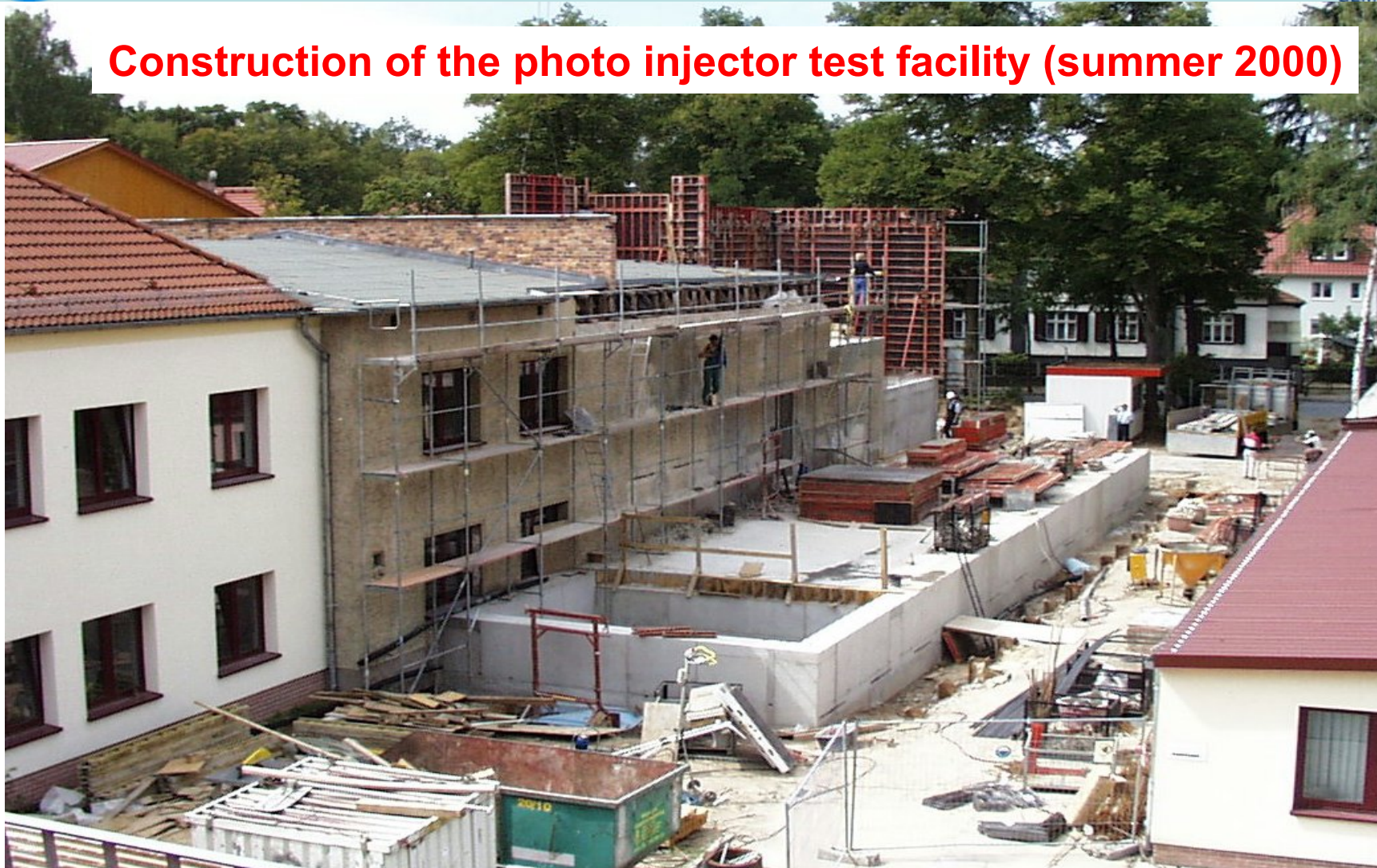
The PITZ project

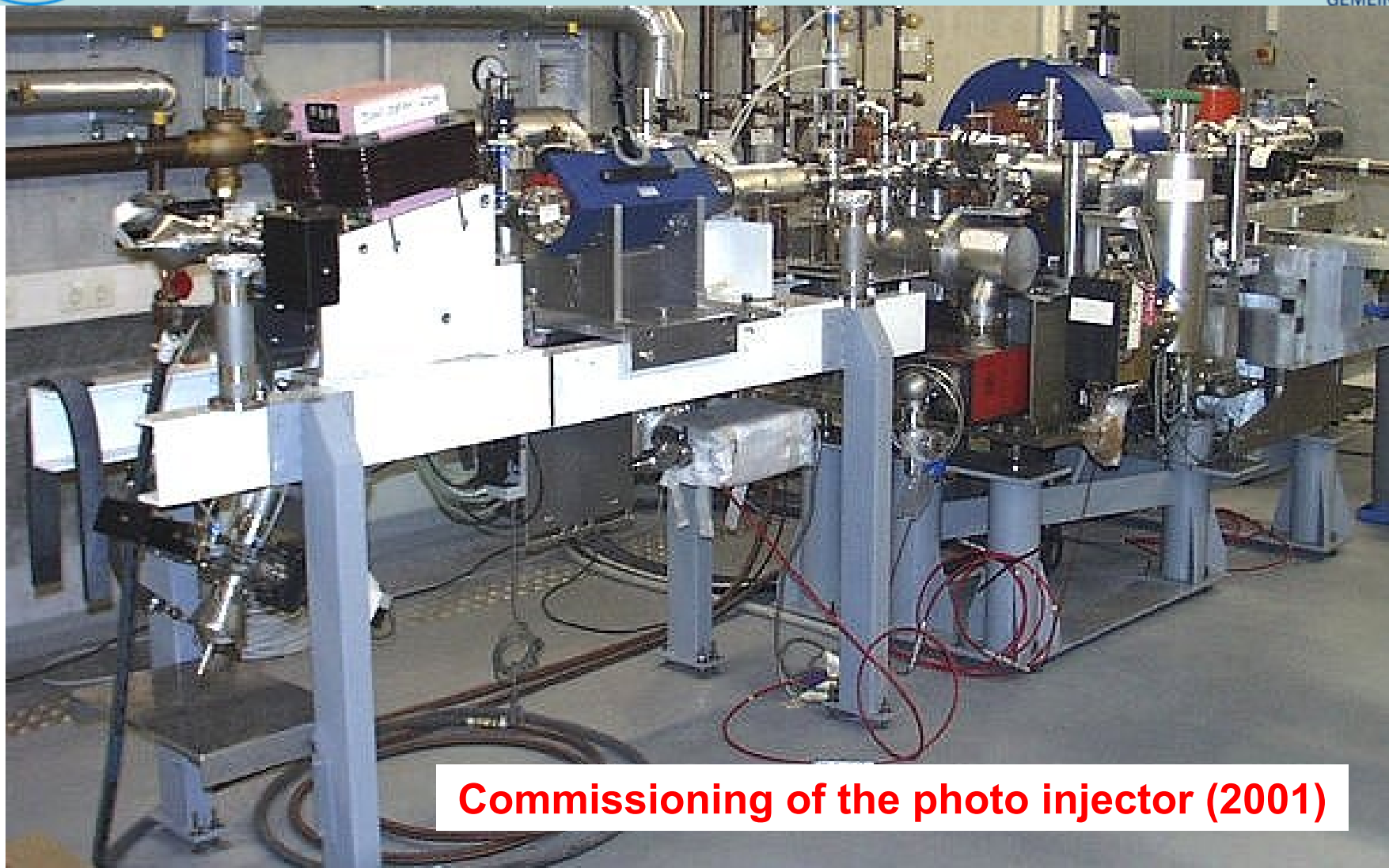


→ construction of a **Photo Injector Test facility** in **Z**euthen with the goals:

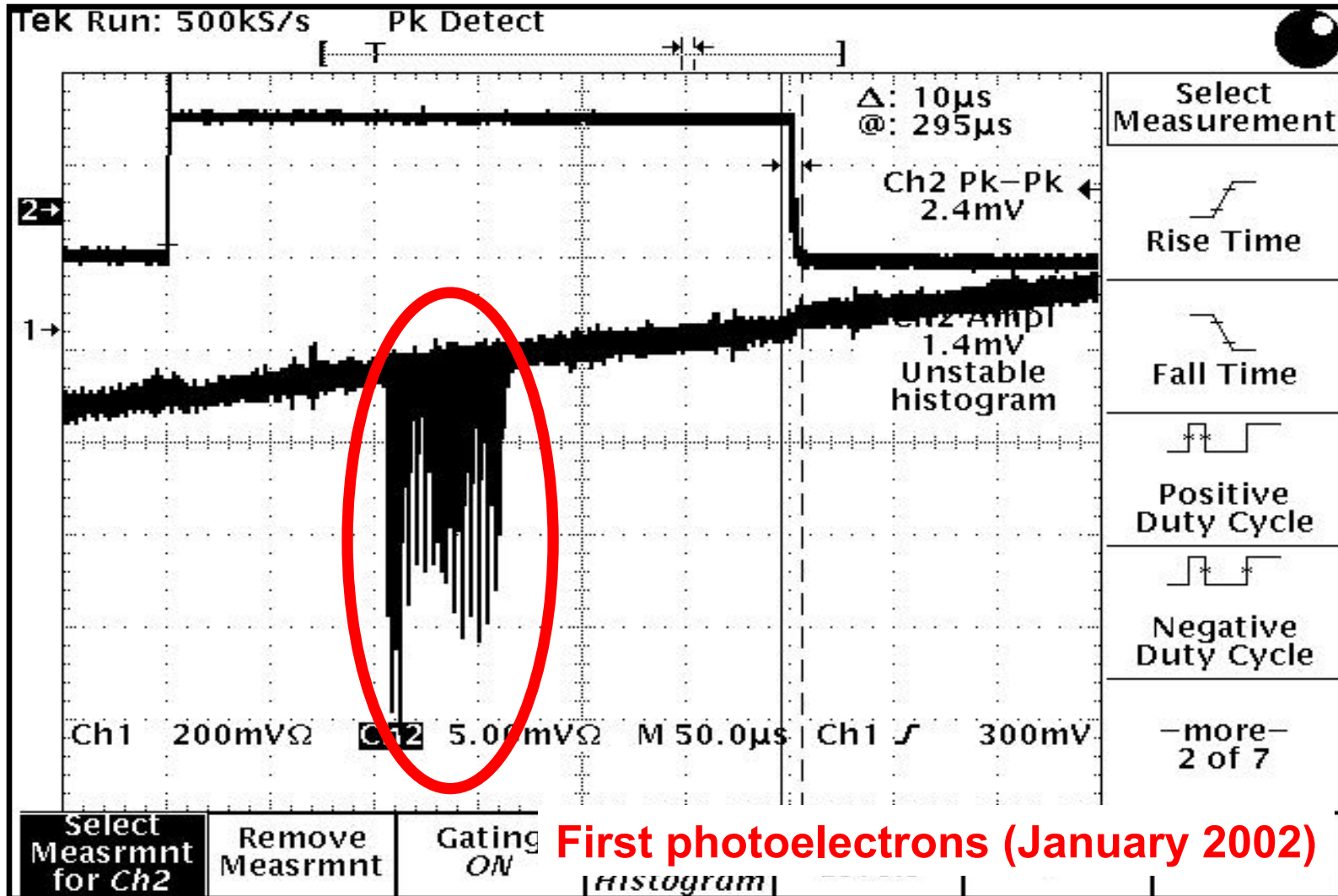
- develop an electron source for the **XFEL**:
 - **very small** transverse emittance ($\leq 1 \text{ mm mrad @ } 1 \text{ nC}$)
 - **stable** production of short bunches with small energy spread
- **extensive R&D** on photo injectors **independent** of serving concrete FEL / user requests
- compare detailed experimental results with simulations:
 - benchmark **theoretical understanding** of photo injectors
- prepare rf guns for subsequent operation at VUV-FEL / XFEL
- test **new developments** (laser, cathodes, beam diagnostics)
- long term plans: e.g. flat beams, polarized electrons for **ILC**

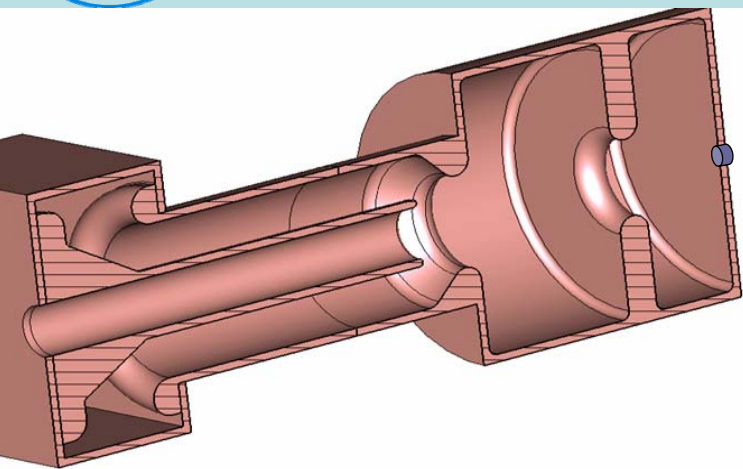
Construction of the photo injector test facility (summer 2000)



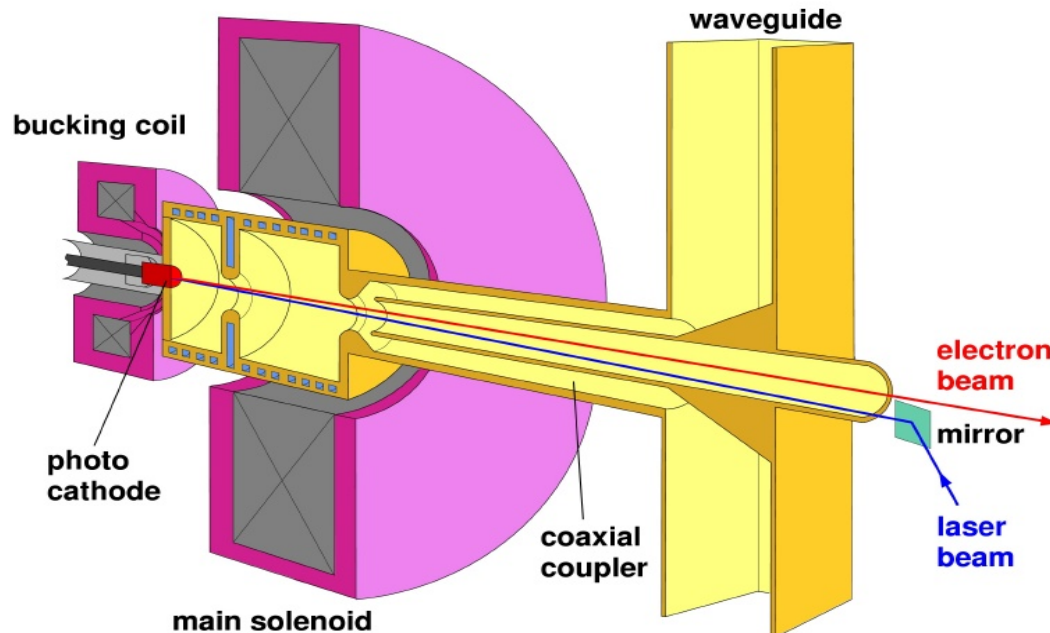
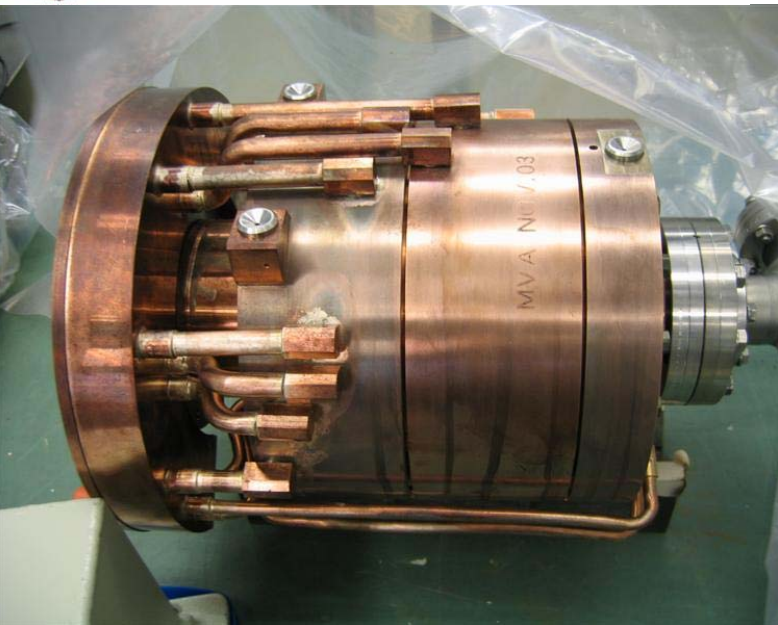


Commissioning of the photo injector (2001)

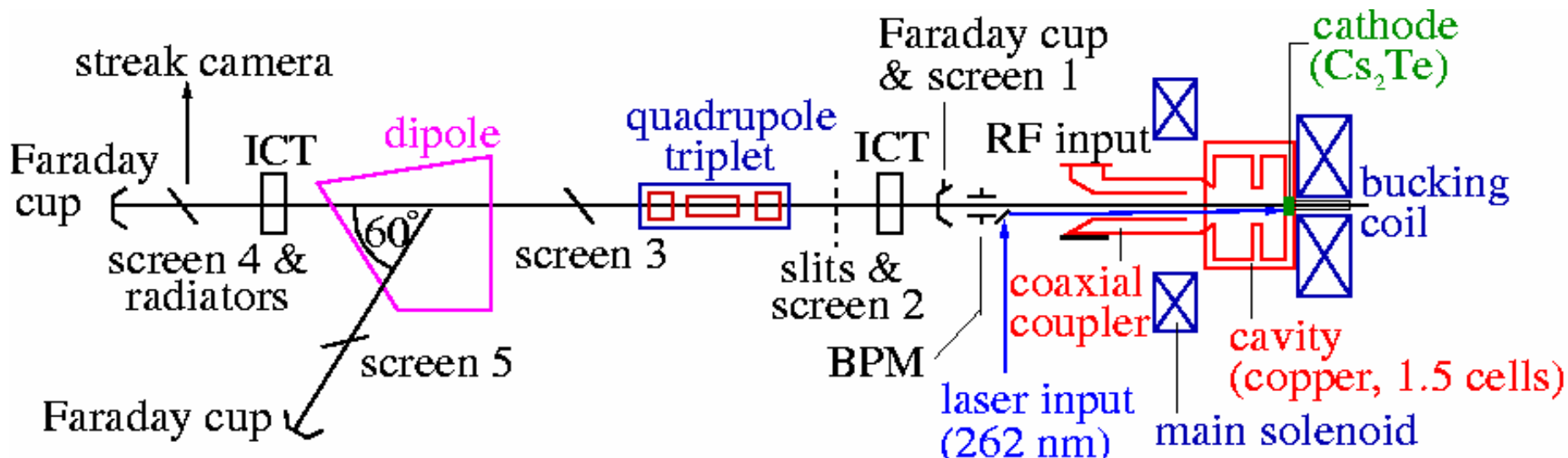




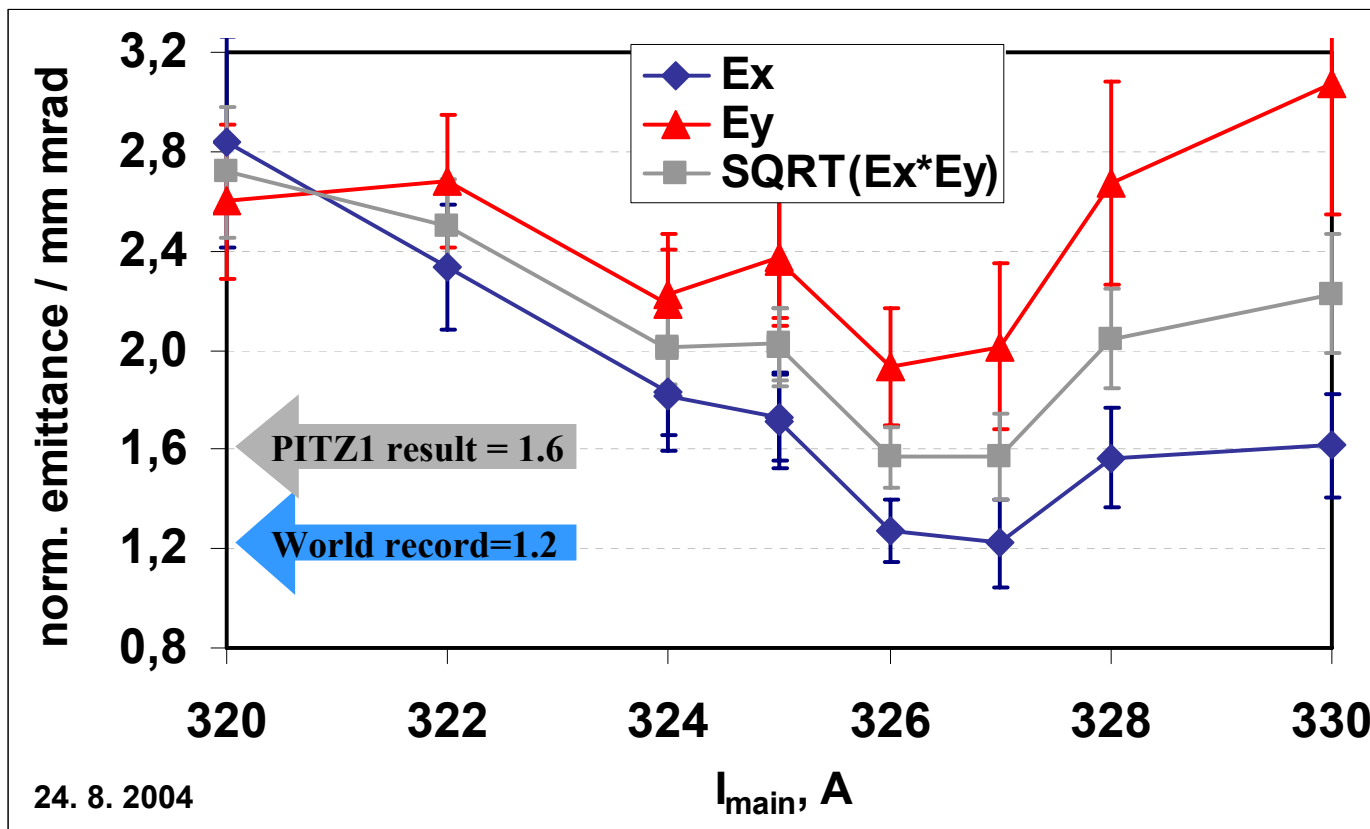
- normal conducting 1.5 cell copper cavity
- frequency: 1.3 GHz (π -mode)
- coaxial RF input coupler
- 3 similar prototypes exist



Schematics:



- PITZ1 phase (2001–2004) included the full characterization of the installed gun cavity
- full parameter optimization for emittance minimization has been done
- very good emittances have been obtained ($\epsilon \sim 1.6 \text{ mm mrad}$)



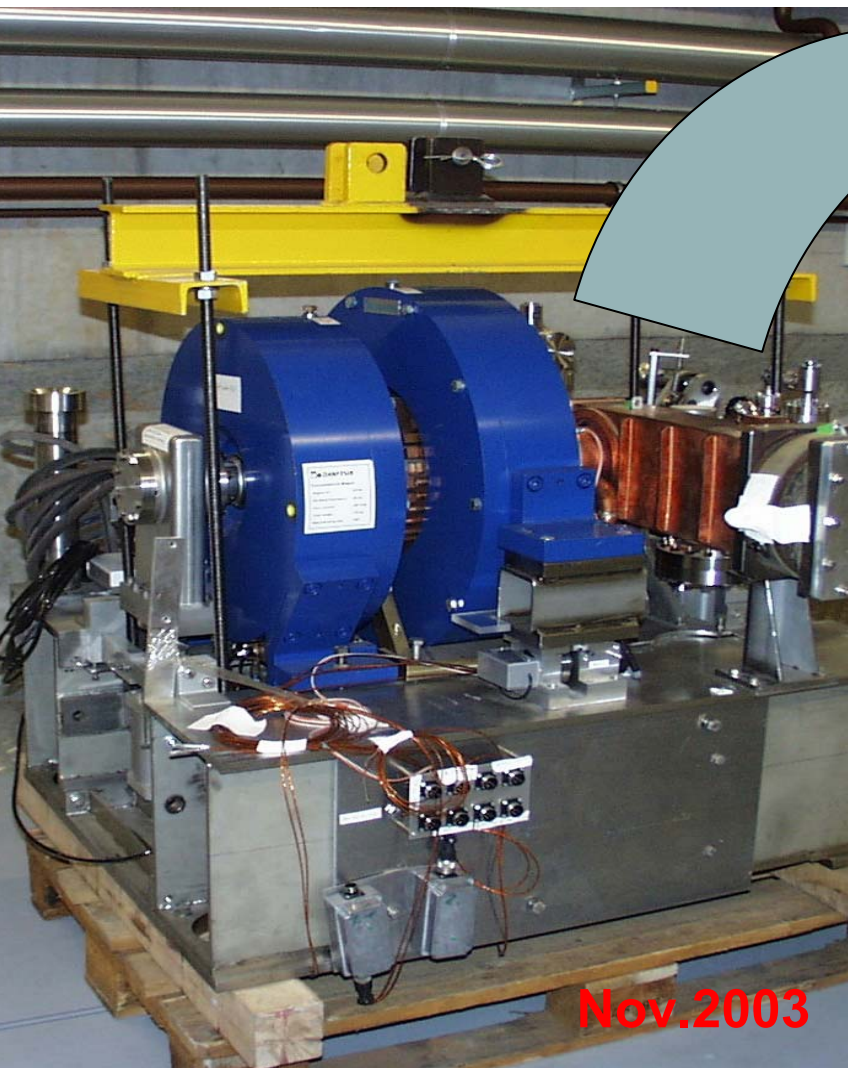
Startup (30 nm)
VUV-FEL = 3.0

Request (6nm)
VUV-FEL = 2.0

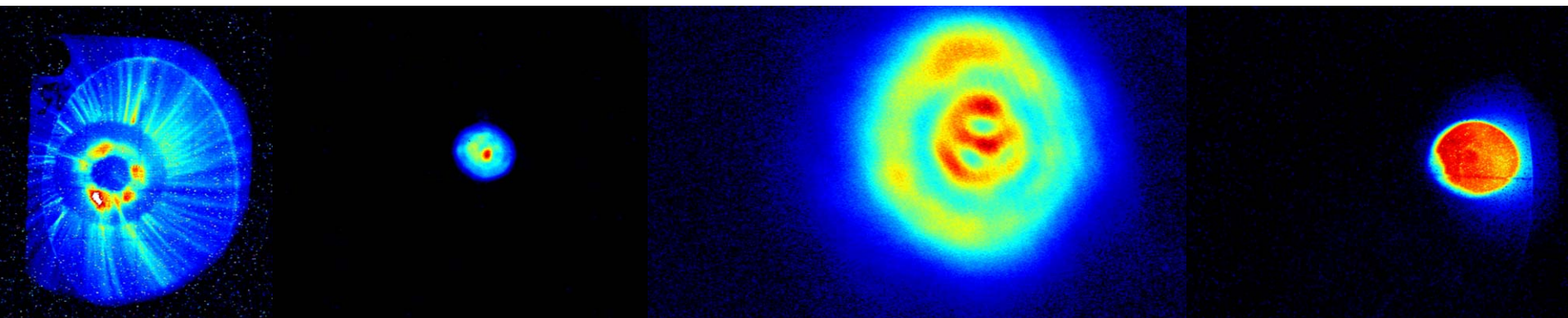
Requirement
for XFEL=0.9

- VUV-FEL startup request clearly fulfilled in 2003
→ gun is transferred to Hamburg and installed in the VUV-FEL
- PITZ continues with a replacement gun

PITZ-gun \rightarrow VUV-FEL



- Conditioning of the Gun cavity and dark current studies
- The laser system / measurement of laser parameters
- Characterization of the electron beam
 - charge
 - momentum and momentum spread
 - bunch length
 - beam size and transverse emittance
 - thermal emittance





PITZ1 results

- Gun conditioning -

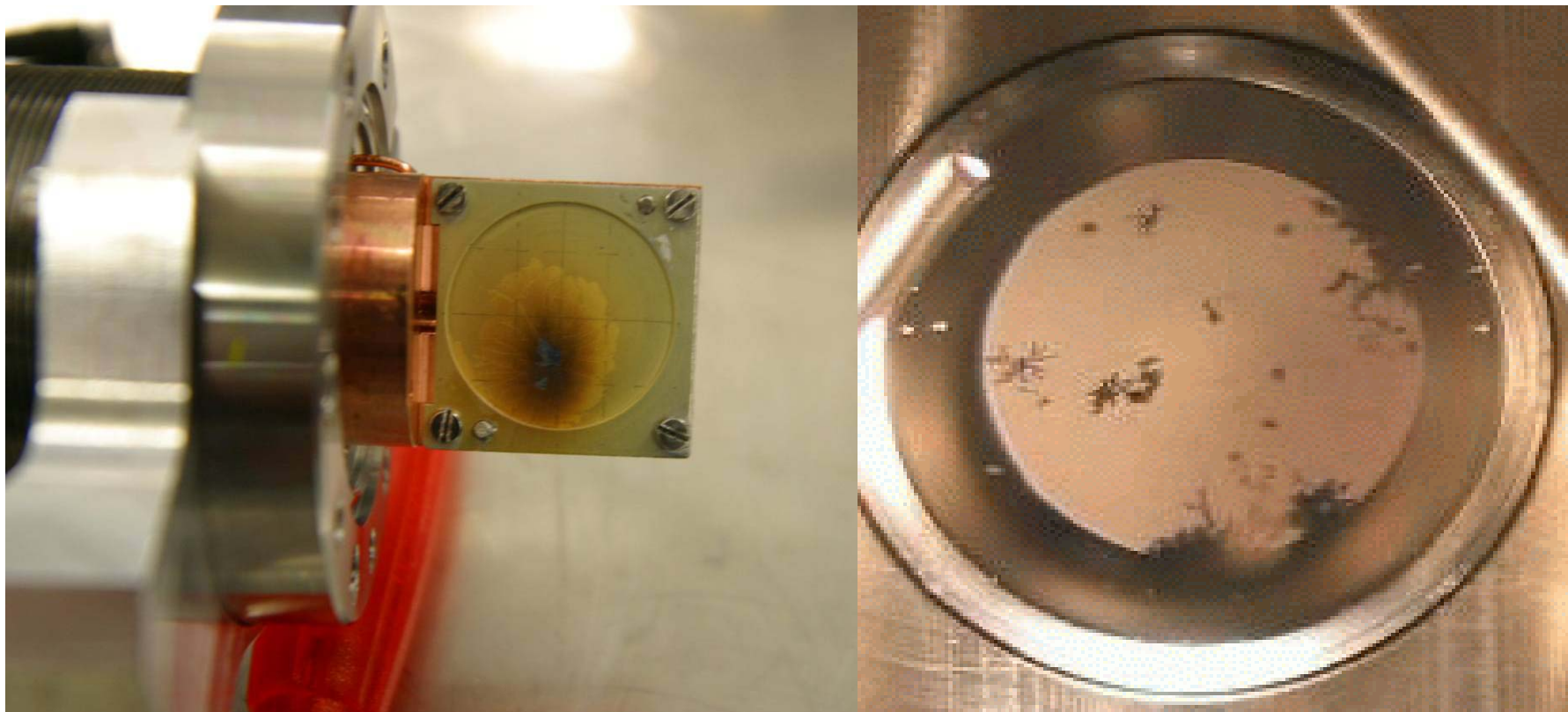


1st Problem: max. acceleration gradient only reachable when full RF power in the cavity

- condition Gun for all possible RF settings (power level, pulse length, repetition rate) and solenoid magnet currents
- mainly improve cavity surface
- field emission (multipacting, sparks) may cause damage of cavity, cathode, coupler, RF window
- vacuum survey during the conditioning process (interlocks)

2nd Problem: dark current is emitted (mainly from cathode) during the full RF pulse duration

- large amount at high power levels / long pulses
- may destroy cathode and diagnostics (e.g. screens)
- can be transported until the undulator and damage it



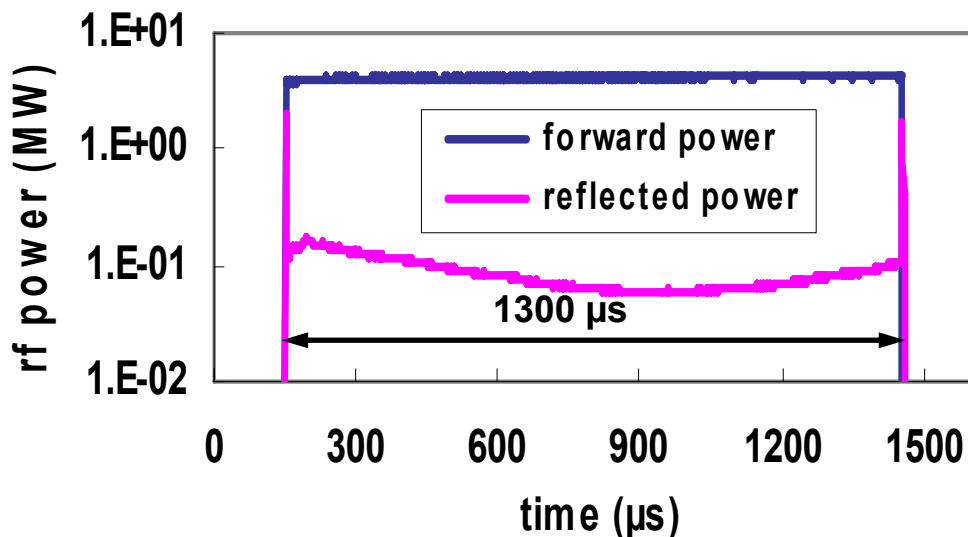
We experienced damages on screens and cathodes.

repetition rate	10 Hz	5 Hz	10 Hz
rf pulse length	0.5 ms	1.3 ms	1.0 ms
peak power at gun	4 MW	4 MW	3 MW
average power	20 kW	26 kW	30 kW
duty cycle	0.5 %	0.65 %	1.0 %

limited by 5 MW klystron and water cooling system



necessary upgrades:
 - 10 MW klystron
 - new cooling system



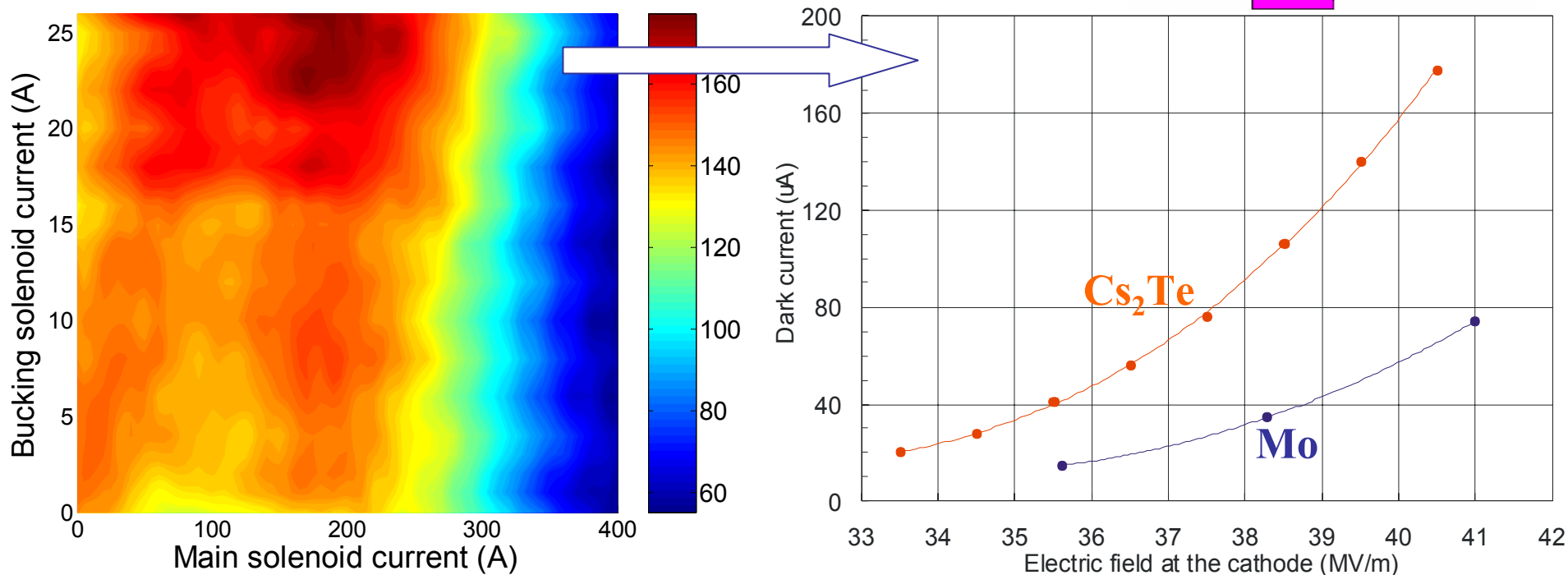
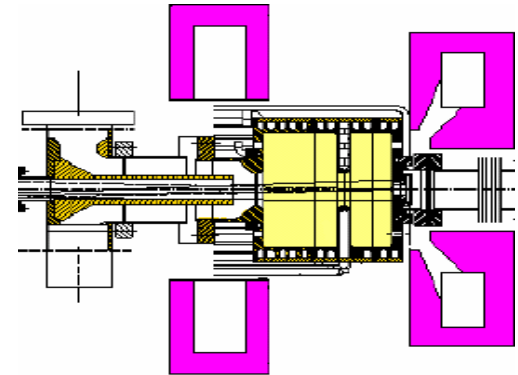
Requirements of VUV-FEL fulfilled

Goal parameters for the XFEL (60 MV/m):
 $\sim 7 \text{ MW}, \leq 0.65 \text{ ms}, 10 \text{ Hz}$

Dark current measurements in dependence on

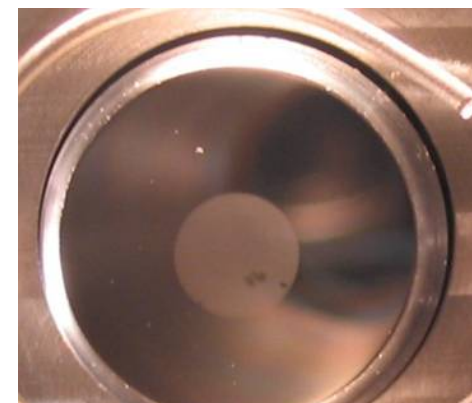
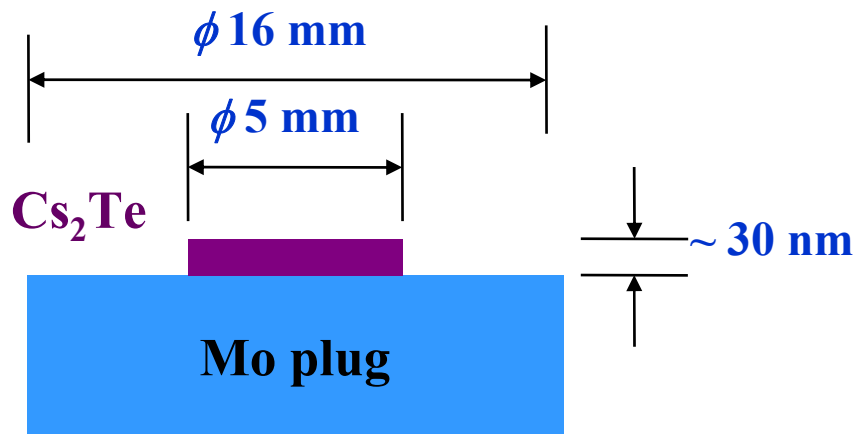
- accelerating gradient at the cathode
- cathode material (Mo / Cs₂Te)
- solenoid current

and its time development





side view of the cathode



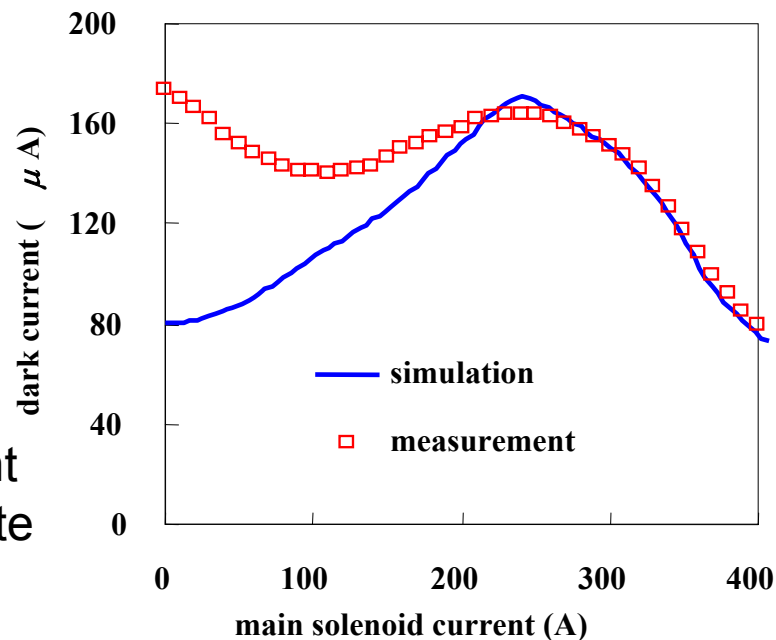
front view of the cathode

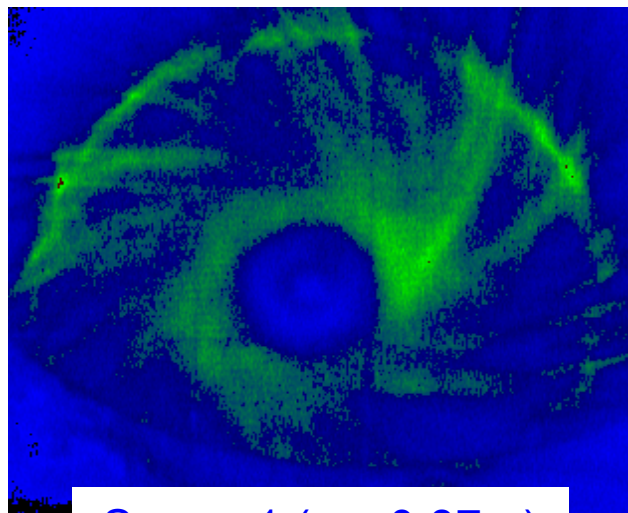
Possible dark current sources:

- Cs₂Te film
- edge of Cs₂Te film
- Mo plug
- edge of Mo plug

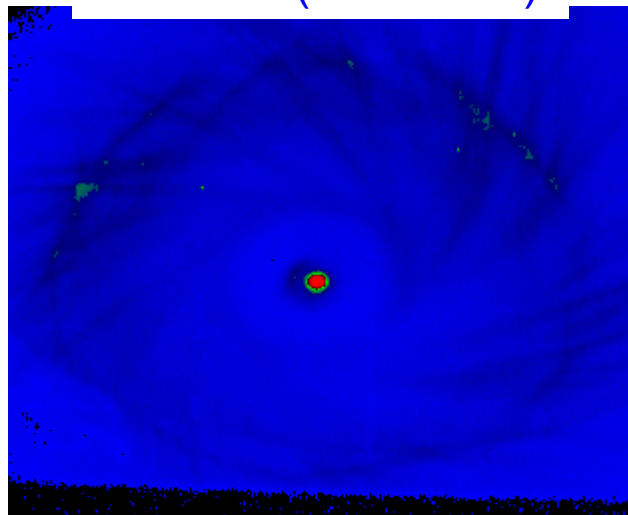
→ field emission model for the cathode

Discrepancy between simulation and measurement
 → additional emission mechanisms could contribute





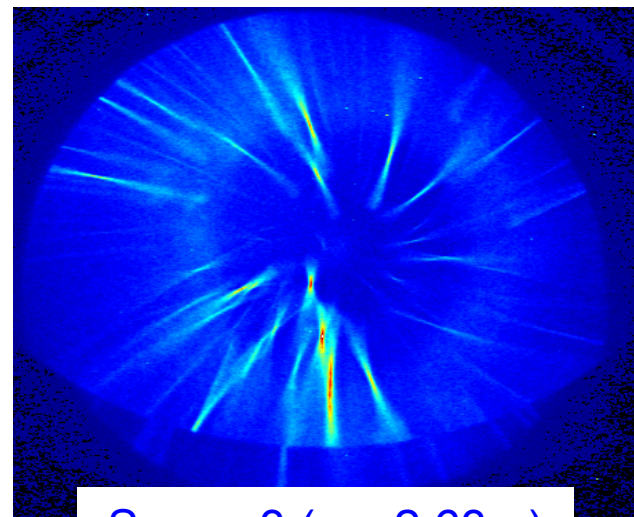
Screen1 ($z = 0.87\text{m}$)



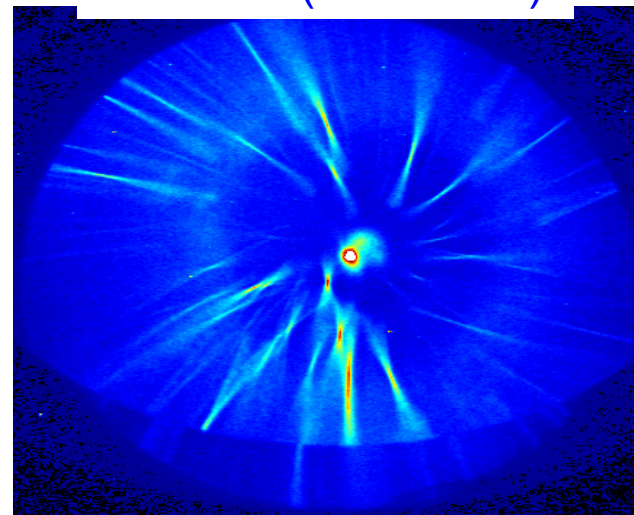
without beam



with beam



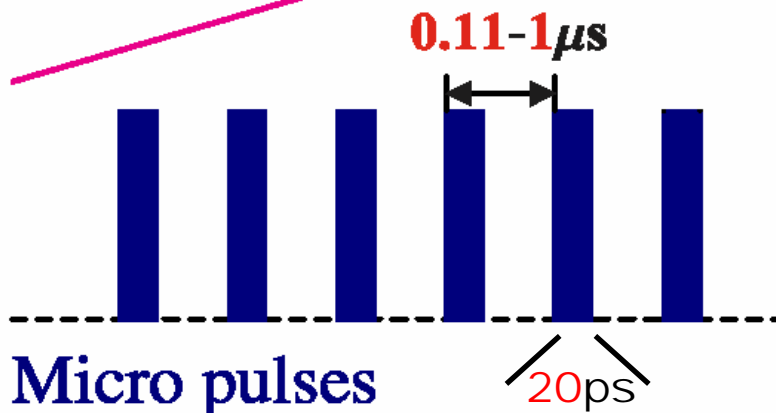
Screen3 ($z = 2.63\text{m}$)



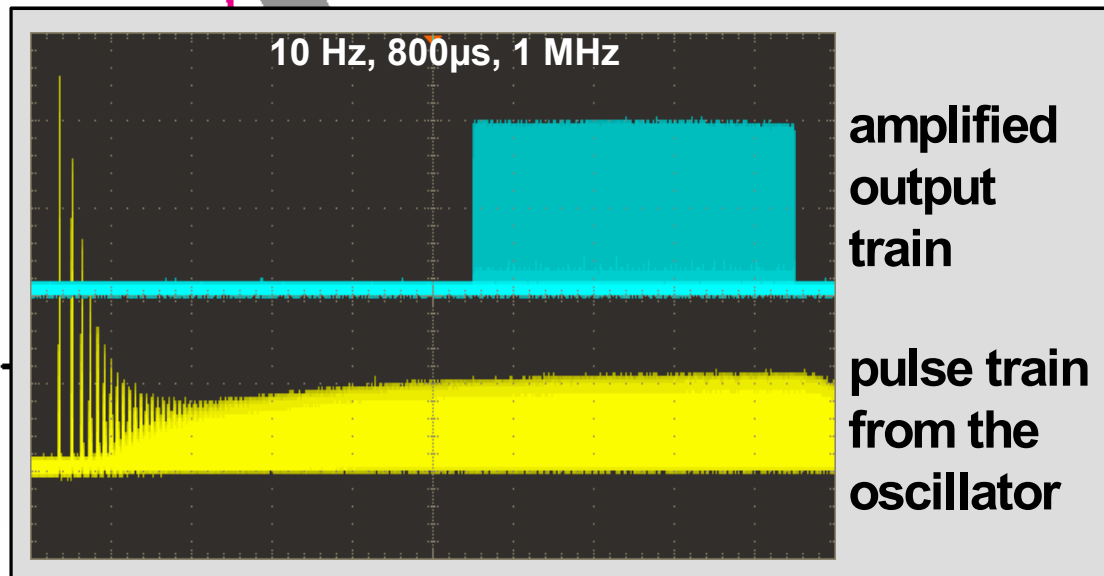
using sc linac technology for VUV-FEL / XFEL → long pulse trains

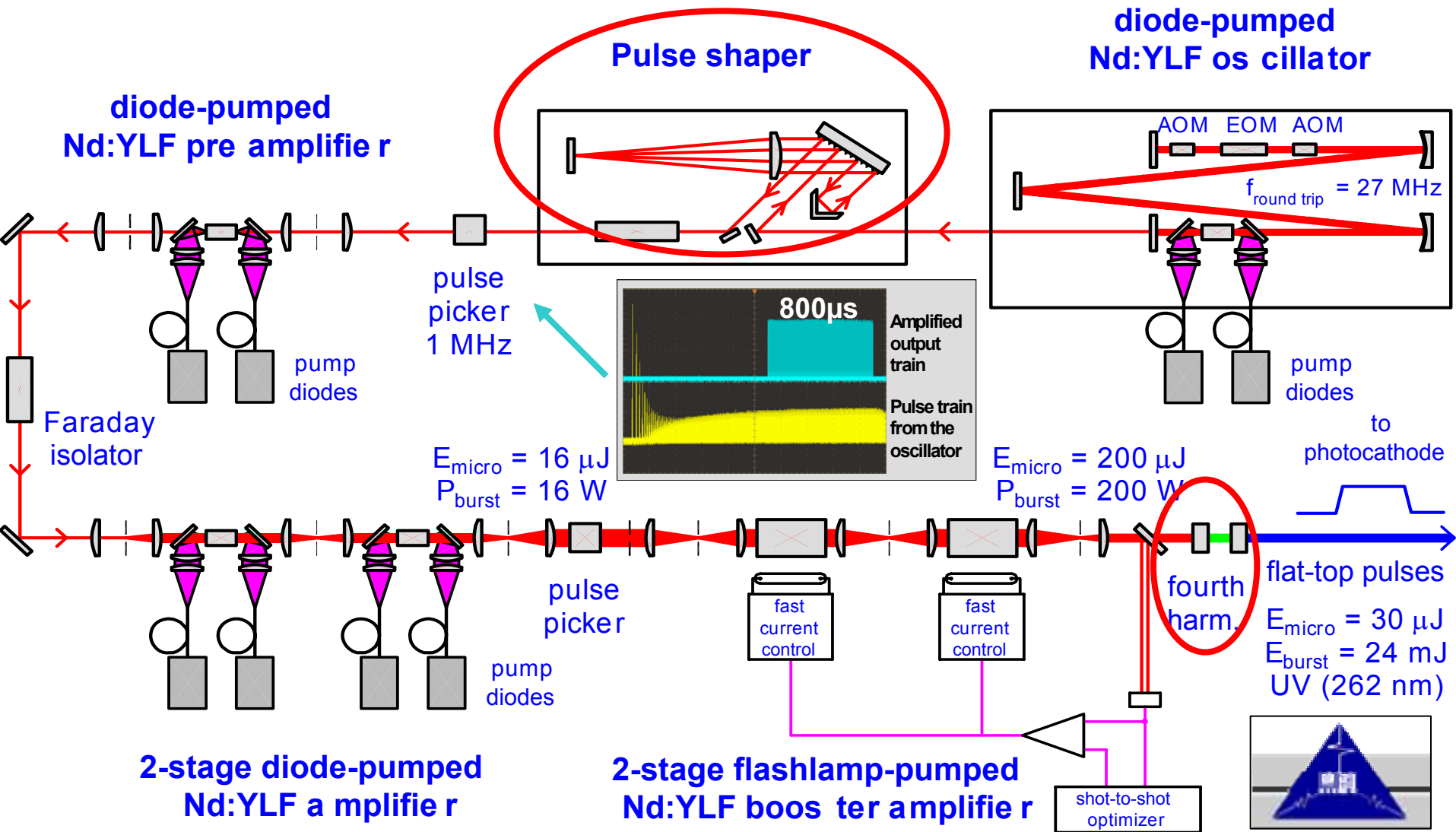


Pulse trains



Micro pulses





Longitudinal laser pulse shape can be changed between

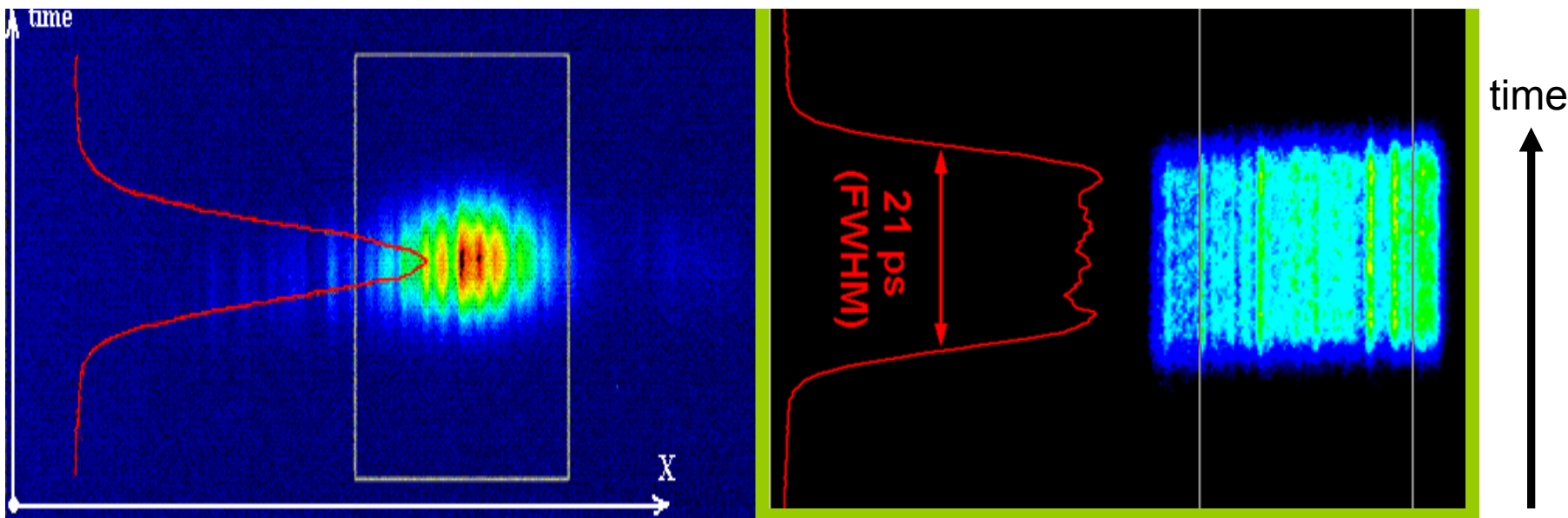
gaussian

e.g. before 23.6.03
FWHM = 7 ± 1 ps

and

flat-top

e.g. after 23.6.03
FWHM ≈ 19 -23 ps
rise / fall time 5-7 ps



Minimum measured emittance:

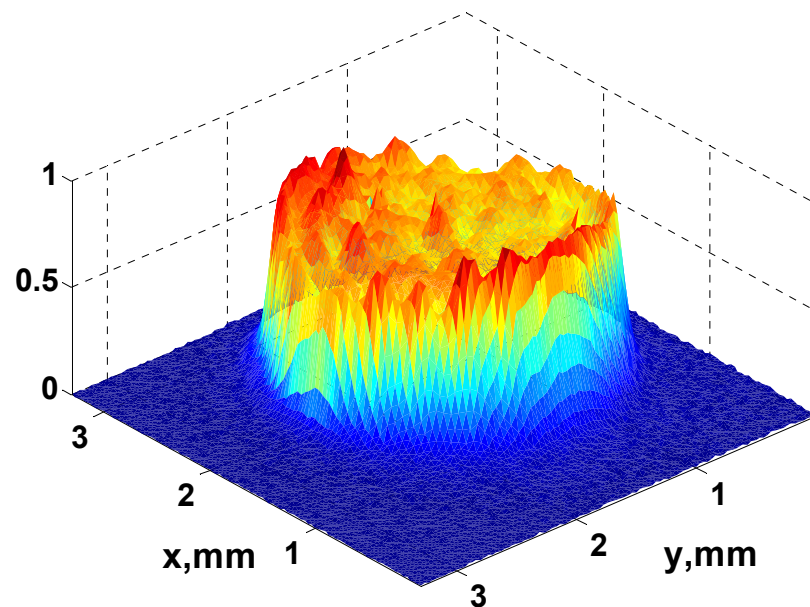
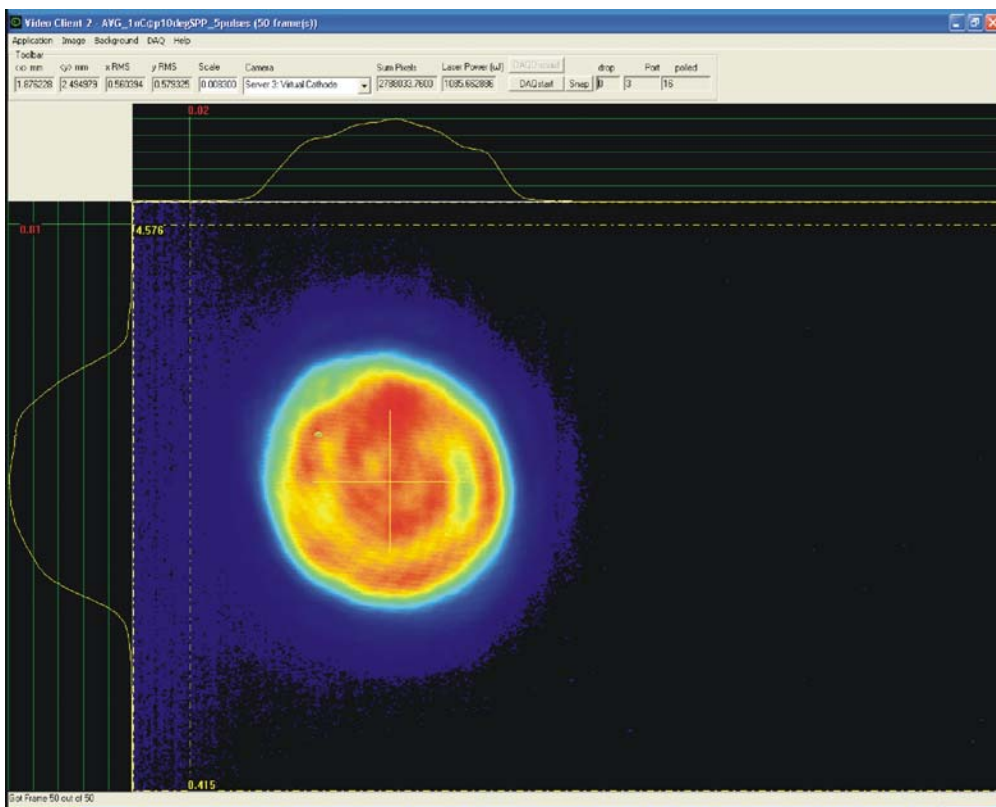
≥ 3 mm mrad

1.6 mm mrad

Transverse laser profile (pictures from the 'virtual cathode')

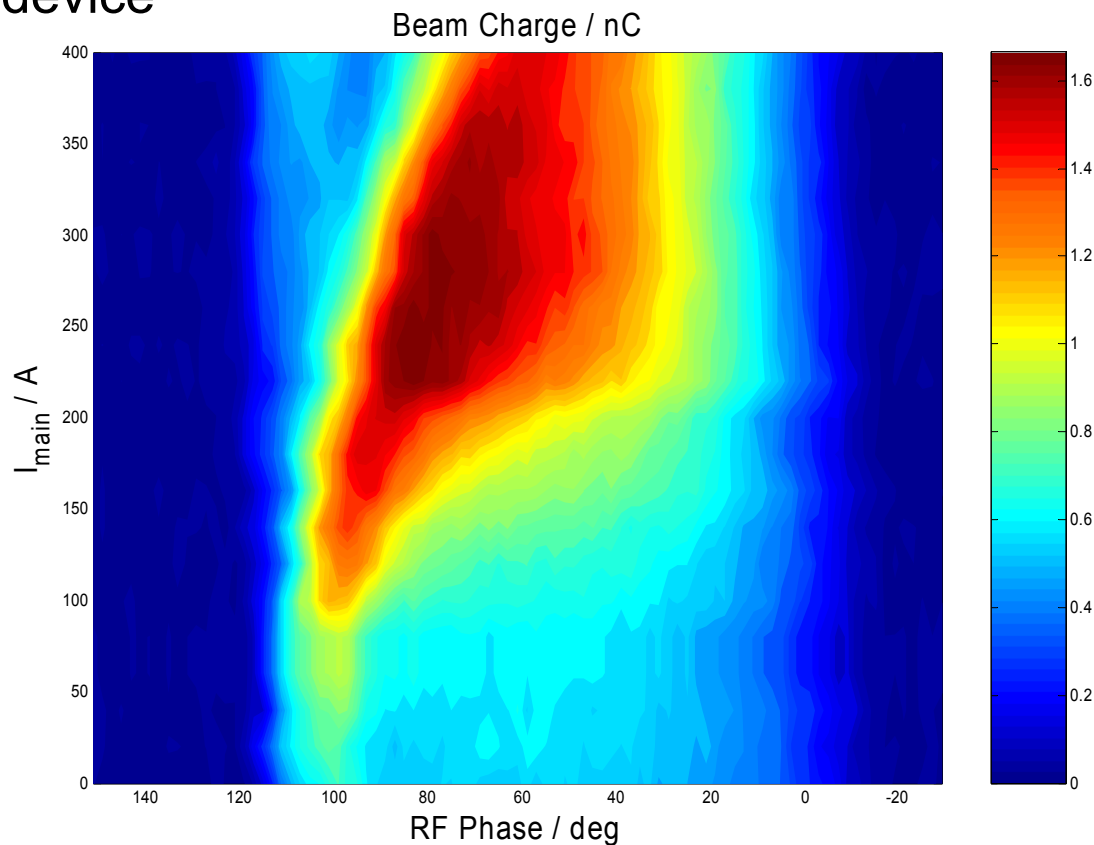
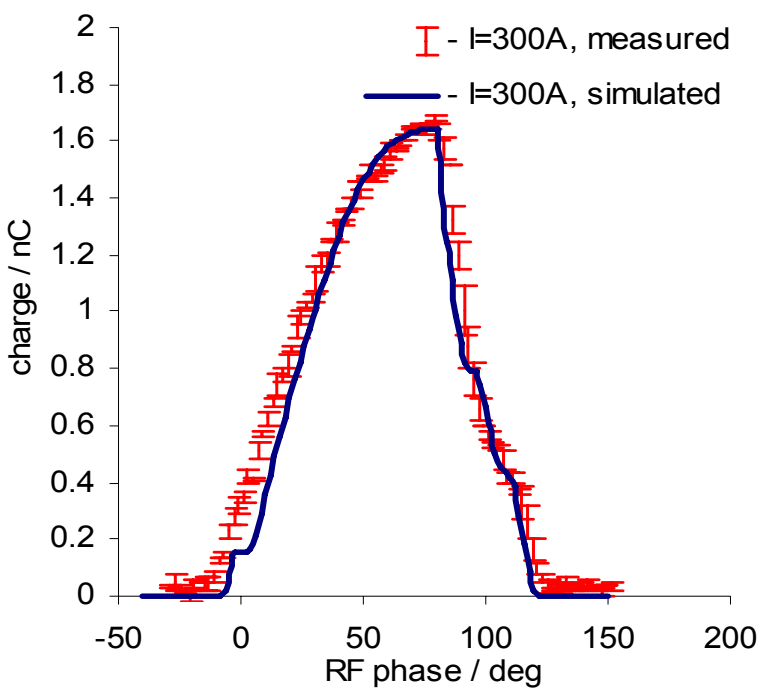
$$\sigma_x = (0.57 \pm 0.02) \text{ mm}$$

$$\sigma_y = (0.58 \pm 0.02) \text{ mm}$$



- charge measurement with FC or ICT
- measured charge depends on
 - position of measurement device
 - phase of the RF field
 - solenoid current

Nominal charge: 1 nC



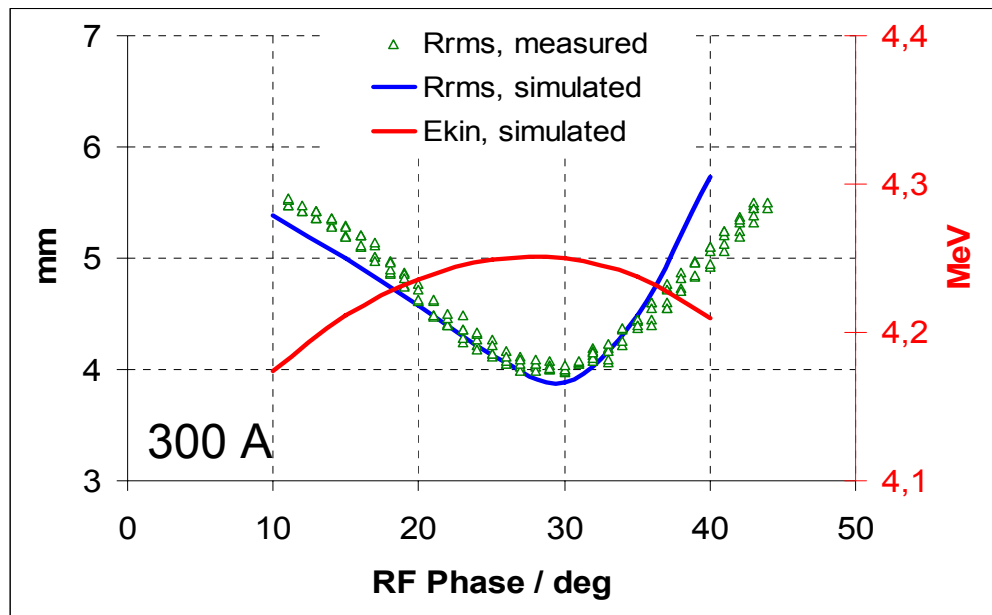
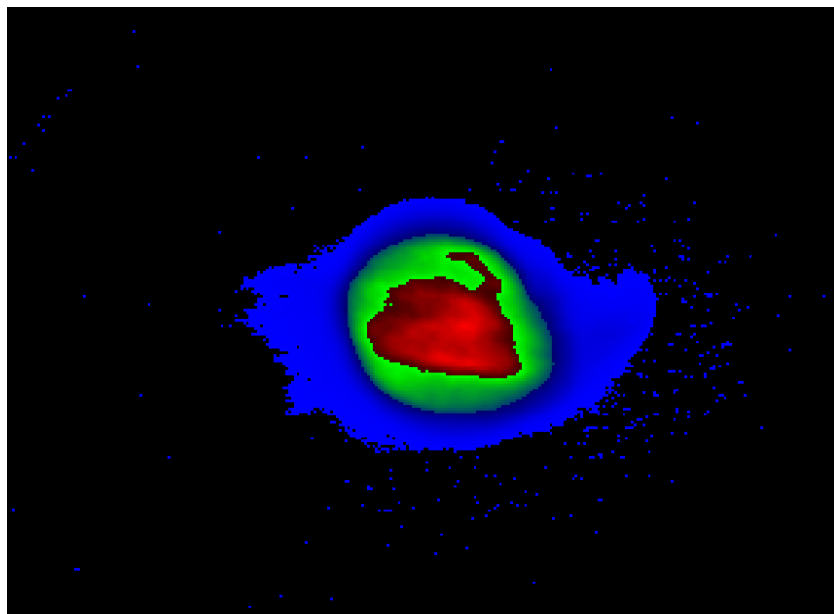
- measured with YAG screen
- study dependence on
 - screen position
 - RF phase
 - solenoid current

Application:

Determination of the reference phase

(phase of maximum energy gain)

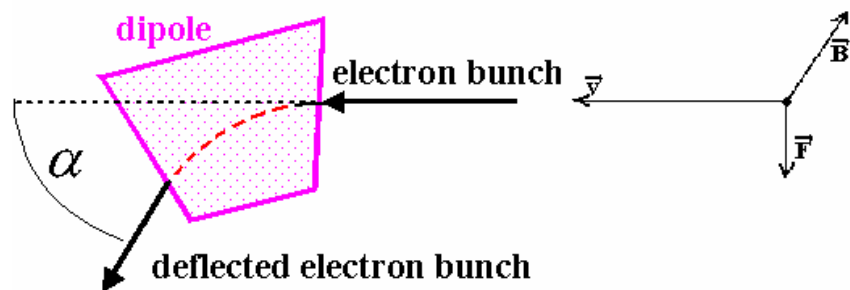
→ measure the electron beam size as function of the launch phase



Principle of momentum measurement

The Lorentz-Force: Motion of electrons with velocity \vec{v} and momentum p in magnetic field \vec{B}

$$\vec{F}_L = e(\vec{E} + \vec{v} \times \vec{B})$$

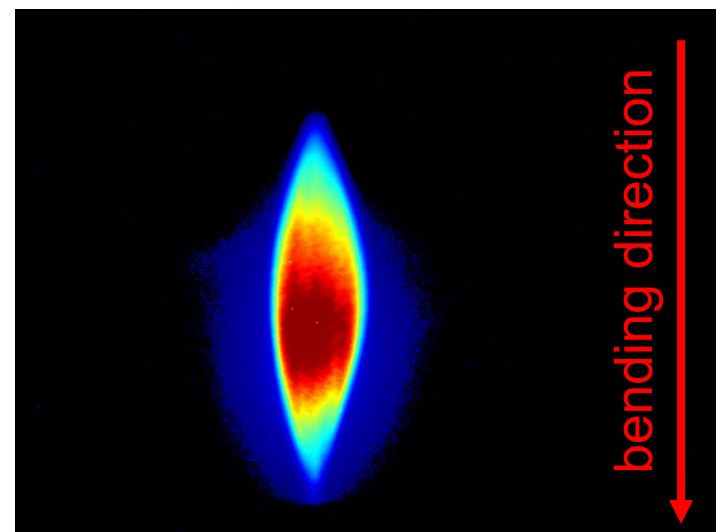


Magnetic Rigidity:

$$\vec{F}_L = evB = \frac{mv^2}{\rho}$$

ρ : Radius of curvature of the path

$$B\rho = \frac{mv}{e} = \frac{p}{e}$$





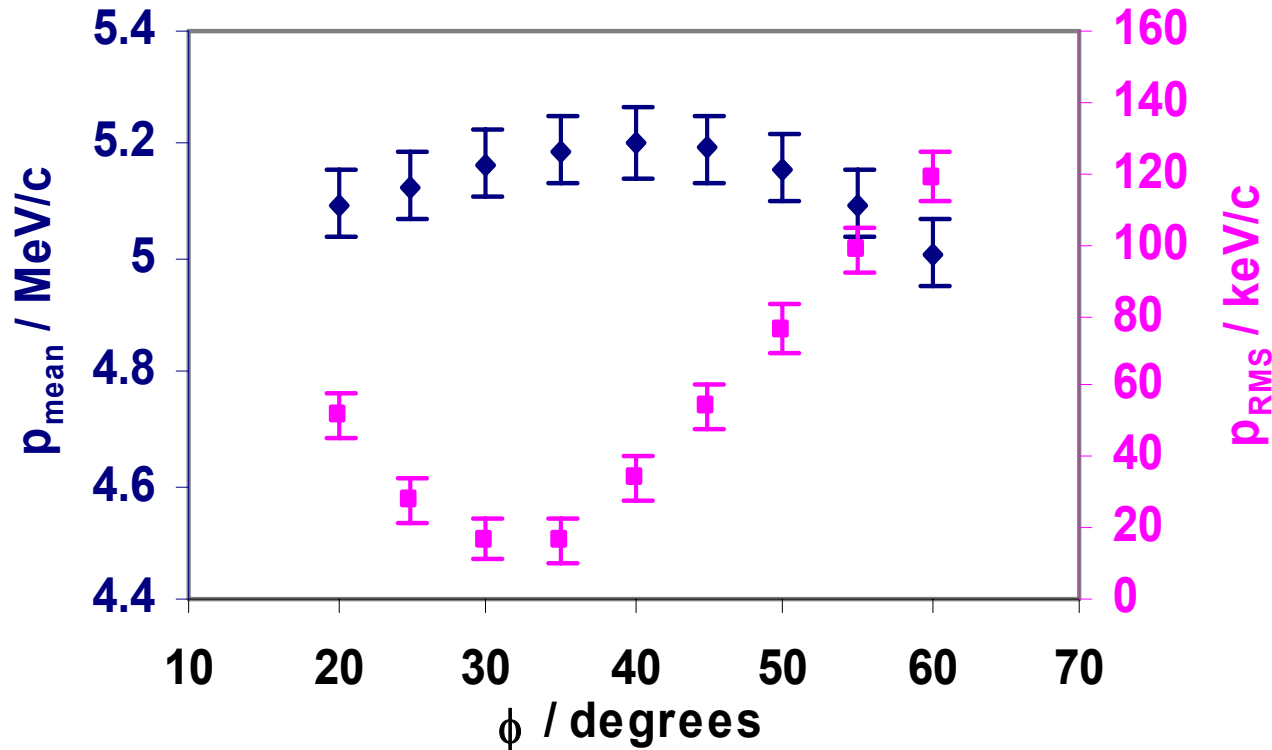
PITZ1 results

- Momentum and momentum spread -



Q = 1 nC

Measurement as function of the RF phase:



**max. mean
momentum:**

5.20 MeV/c

**min. rms momentum
spread:**

16 keV/c

**phase difference
between $p_{\text{mean}}^{\text{max}}$**

and $p_{\text{RMS}}^{\text{min}}$

only ~5 degrees

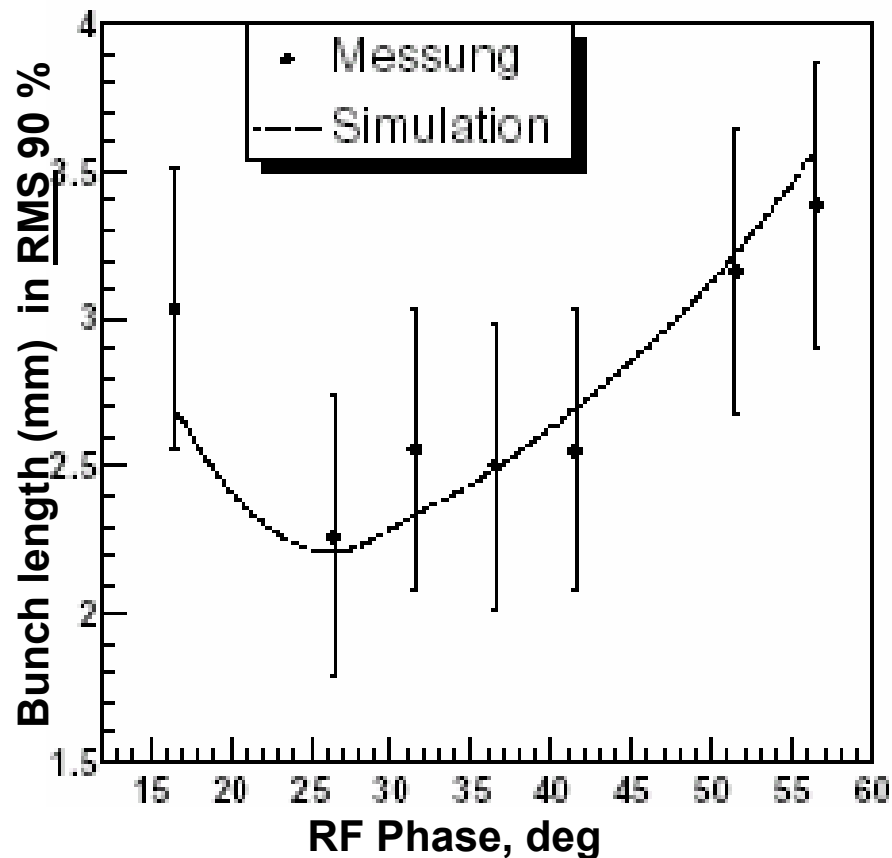
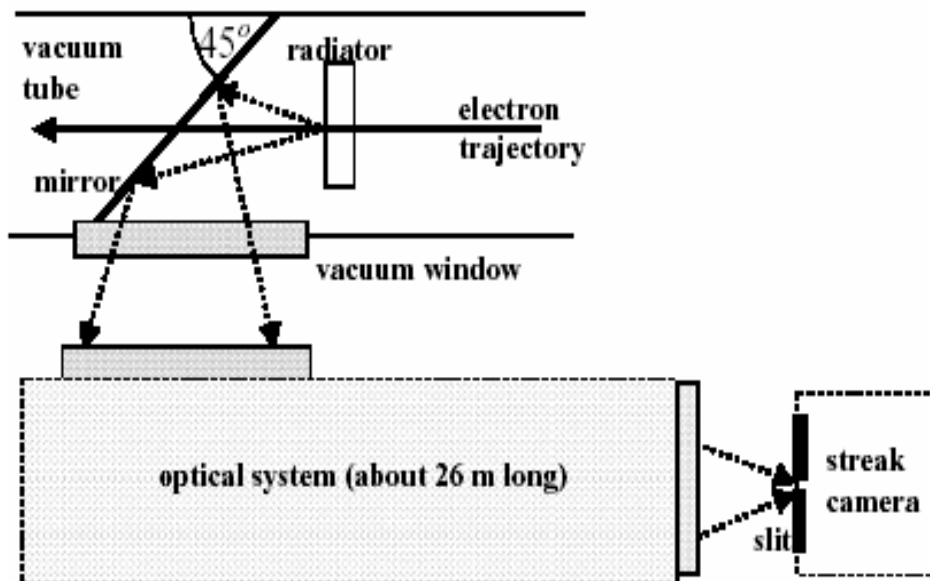
Principle:

- electron bunch hits radiator (aerogel / quartz) and radiates photons
- analysis of time development with streak camera

Minimum length (FWHM):

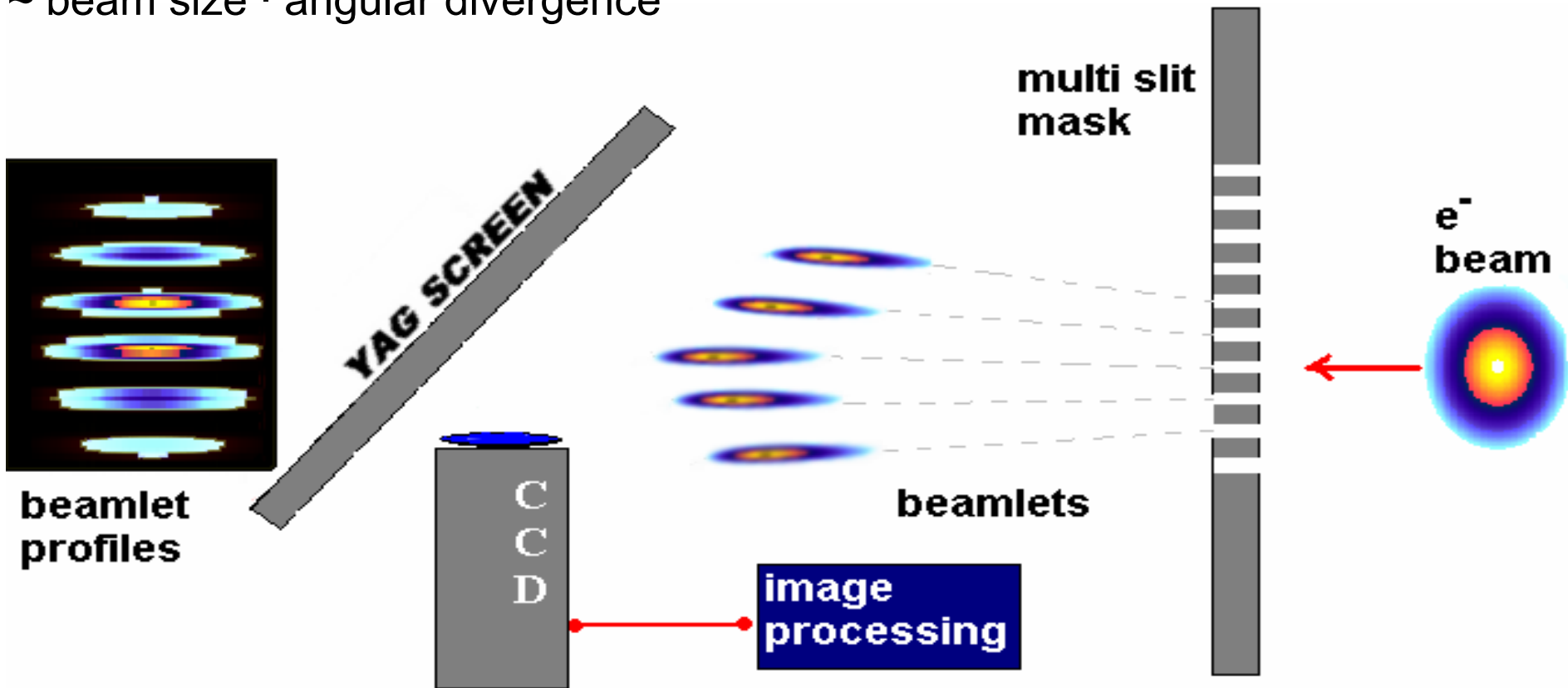
$(21.04 \pm 0.45_{\text{stat}} \pm 4.14_{\text{syst}})$ ps

$(6.31 \pm 0.14_{\text{stat}} \pm 1.24_{\text{syst}})$ mm

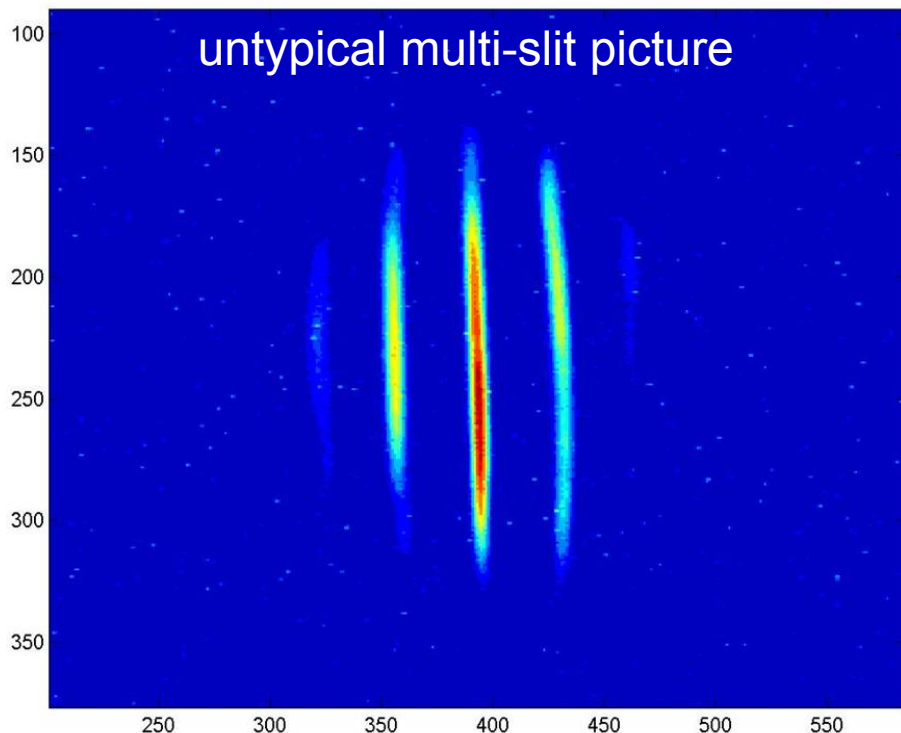


transverse normalized emittance
 ~ beam size · angular divergence

$$\varepsilon_n^2 = \langle x^2 \rangle \langle x'^2 \rangle - \langle x x' \rangle^2$$



phase space reconstruction = approximation of real phase space



Problems with multi-slit measurements:

- overlapping beamlets (large divergence)
- only few beamlets (small beam size)

→ not used at PITZ

Multi-slit mask

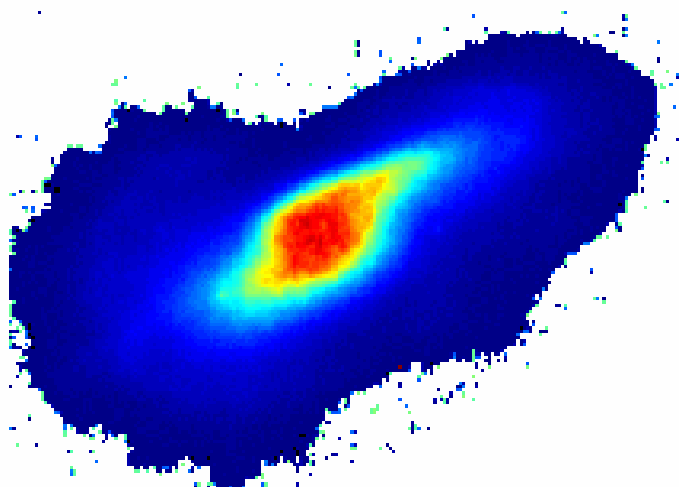
Pepperpot

Single slit



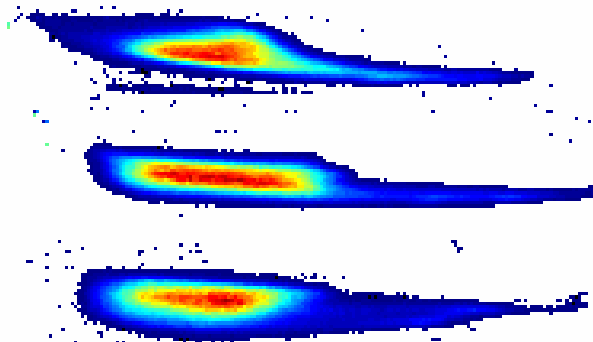
Single-slit scan technique

Beam spot



single slit
position

Beamlets



The size of the beamlet is measured for three slit positions:

$$y_n = \langle Y \rangle + n \cdot 0.7 \sigma_y$$

$$n \in \{-1, 0, 1\}$$

Simulated emittance for optimum parameters

Charge: 1 nC

Max. gradient: 42 MV/m

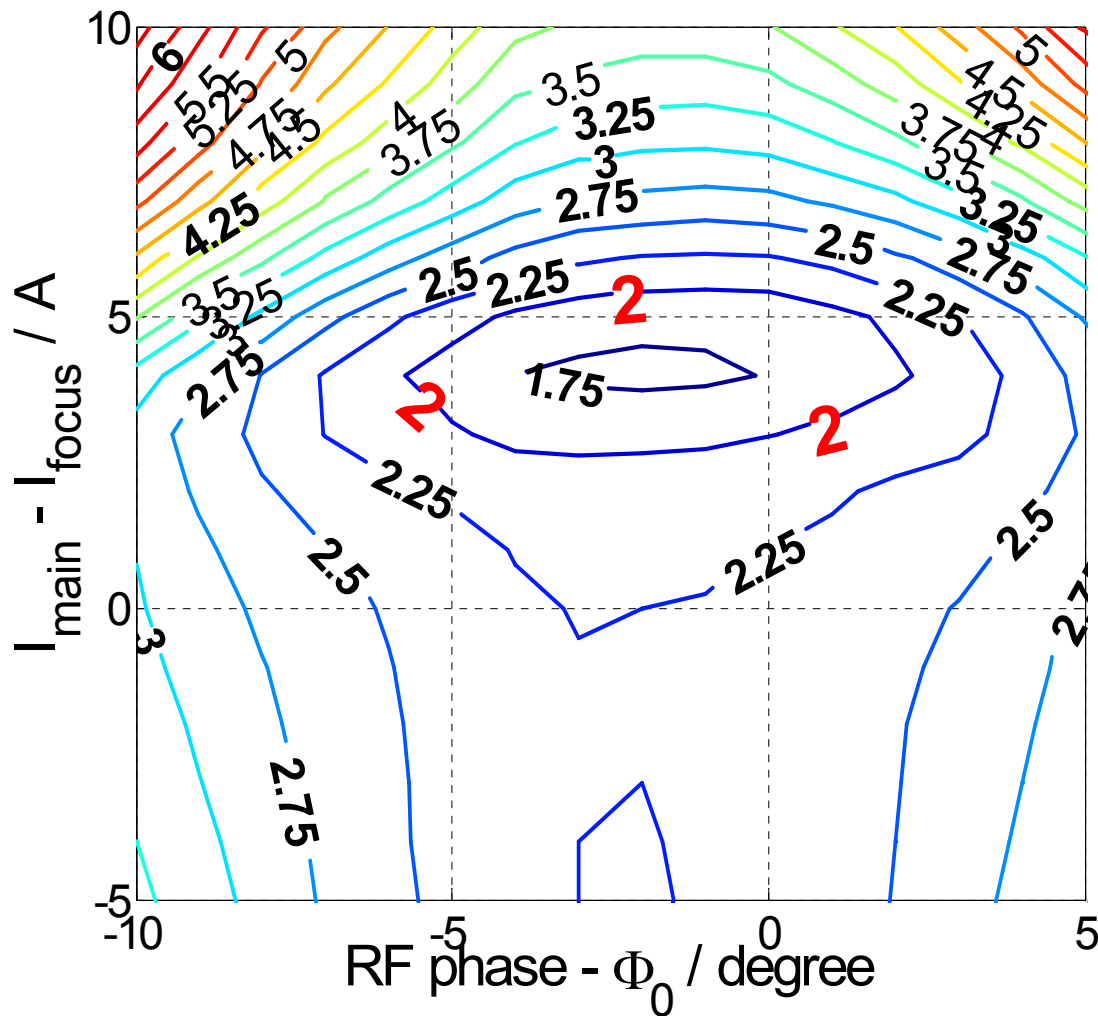
Longitudinal laser profile:

- flat top
- 20 ps FWHM
- 5 ps rise/fall time

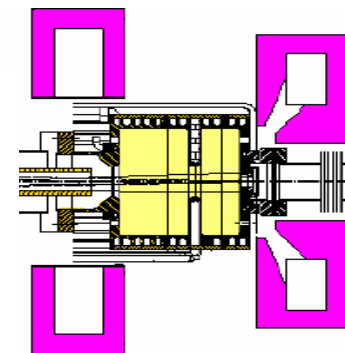
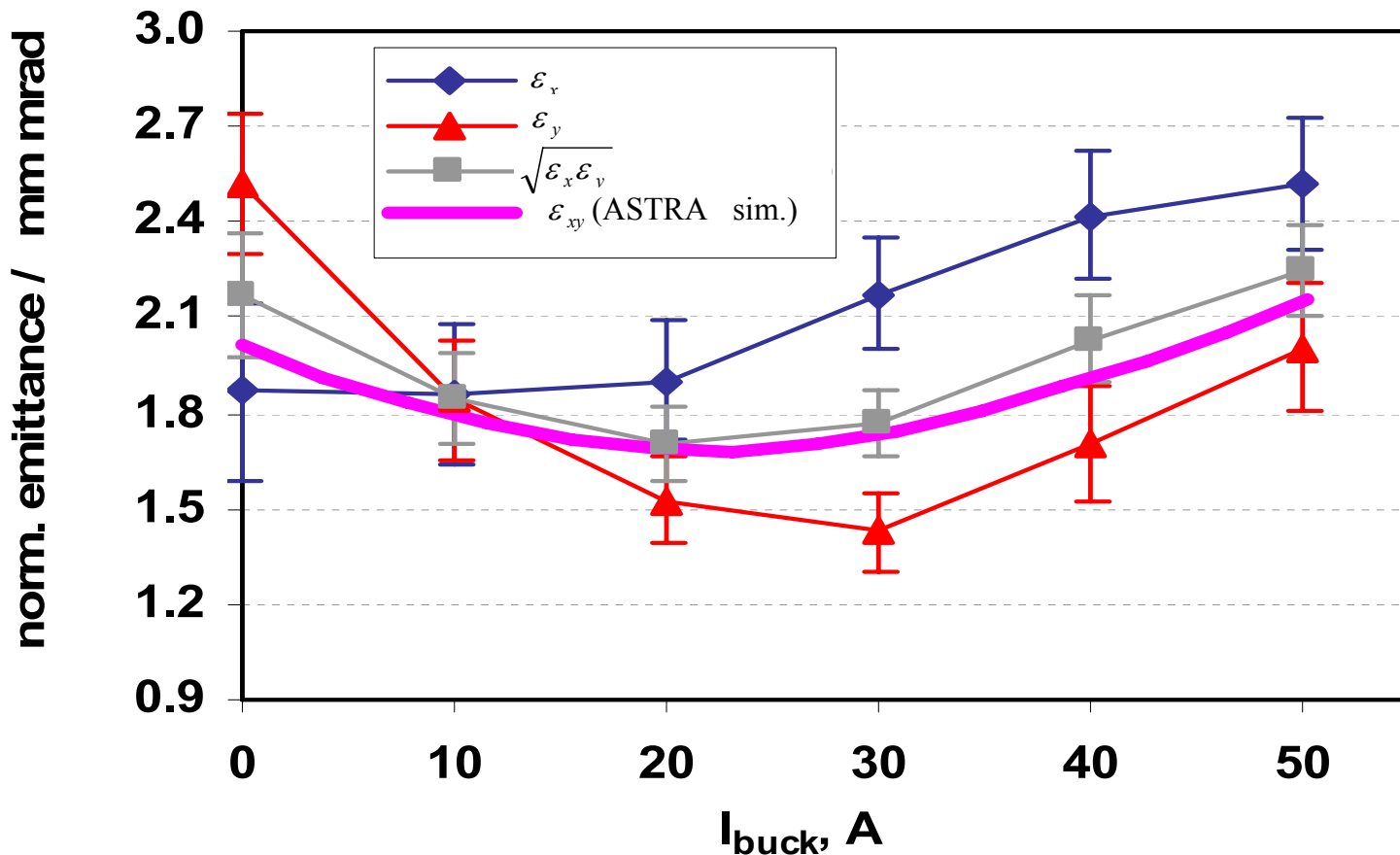
Transverse laser profile:

- homogeneous
- $\sigma_{x,y} = 0.6$ mm

Simulated EmittanceXY / π mm mrad



e.g. measured transverse emittance as function of the current in the compensating magnet



$Q = 1 \text{ nC}$
 $\Phi = \Phi_0 - 5^\circ$
 $I_{\text{main}} = 305 \text{ A}$

$$\varepsilon_{th} = \sigma \sqrt{\frac{2E_k}{3m_0c^2}}$$

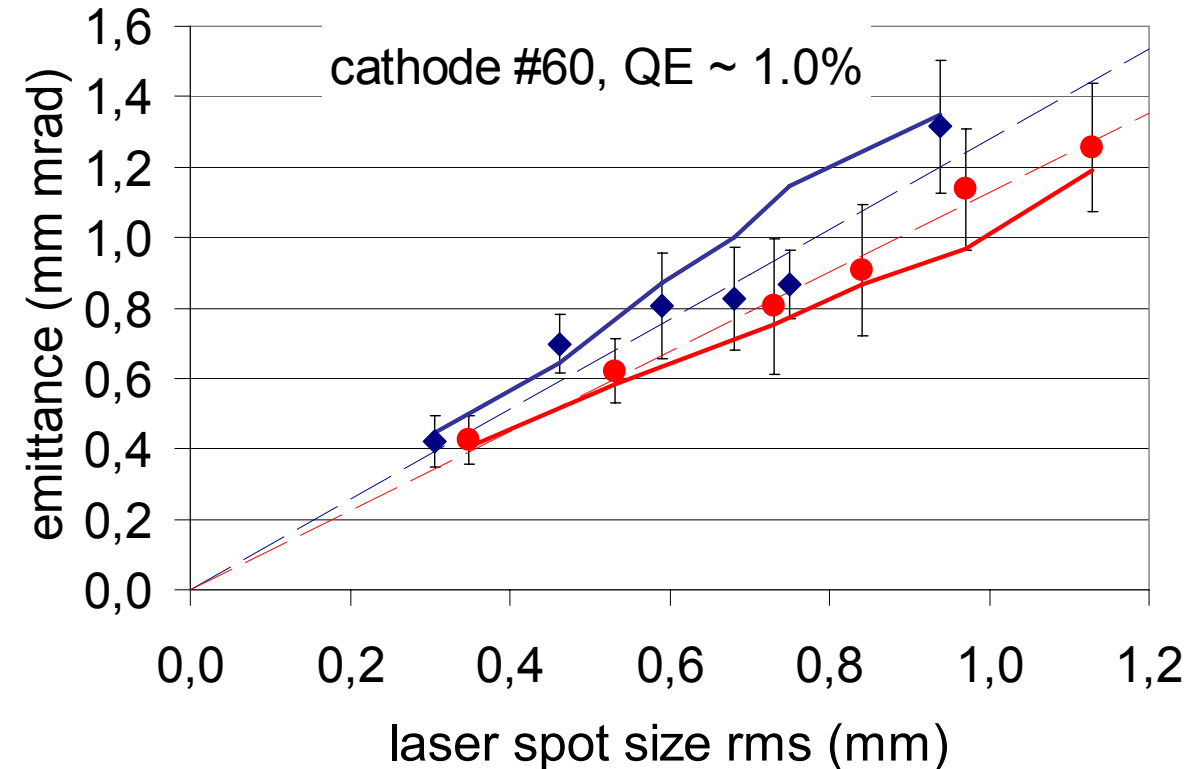
← average kinetic energy of the emitted photo electrons
← laser spot size

- thermal emittance adds in quadrature to the other emittance contributions:

$$\varepsilon_n \approx (\varepsilon_{th}^2 + \varepsilon_{rf}^2 + \varepsilon_{sc}^2)^{1/2}$$

→ thermal emittance sets the **lower emittance limit** of an electron source

- define operation conditions such that $\varepsilon_{rf} \ll \varepsilon_{th}$ and $\varepsilon_{sc} \ll \varepsilon_{th}$:
 $Q \sim 2-3$ pC, $\sigma_t = 3$ ps, $E_0 < 34$ MV/m, laser spot size: 0.48 - 0.55 mm



Kinetic energy of the emitted electrons:

Cathode #60:

(QE ~ 1%)

$$E_k = (1.1 \pm 0.2) \text{ eV}$$

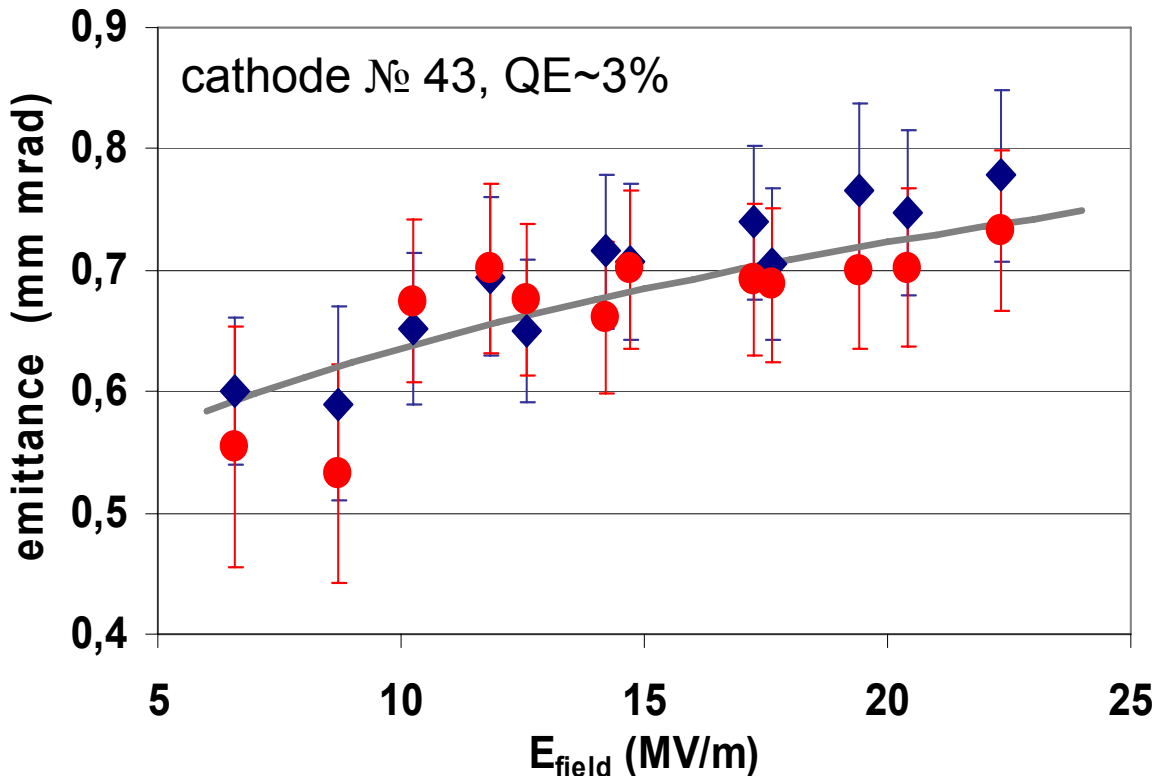
Cathode #61:

(QE ~ 1.5%)

$$E_k = (0.9 \pm 0.2) \text{ eV}$$

- thermal emittance is **individual** for each photocathode
- depends on gun operation history and cathode surface chemistry: $\epsilon_{th} = \epsilon_{th}(t)$
- more **cathode studies** are needed (INFN-LASA)

Impact of the electric rf field



Assuming emittance growth due to Schottky effect:

$$\varepsilon_{th} = \sqrt{A + B\sqrt{E_{field}}}$$

Cathode #43:

(Nov.2004, QE ~ 3%)

$$\varepsilon_{\#43} = \sqrt{0.08 + 0.11\sqrt{E}}$$

Cathode #61:

(Apr.2004, QE ~ 1%)

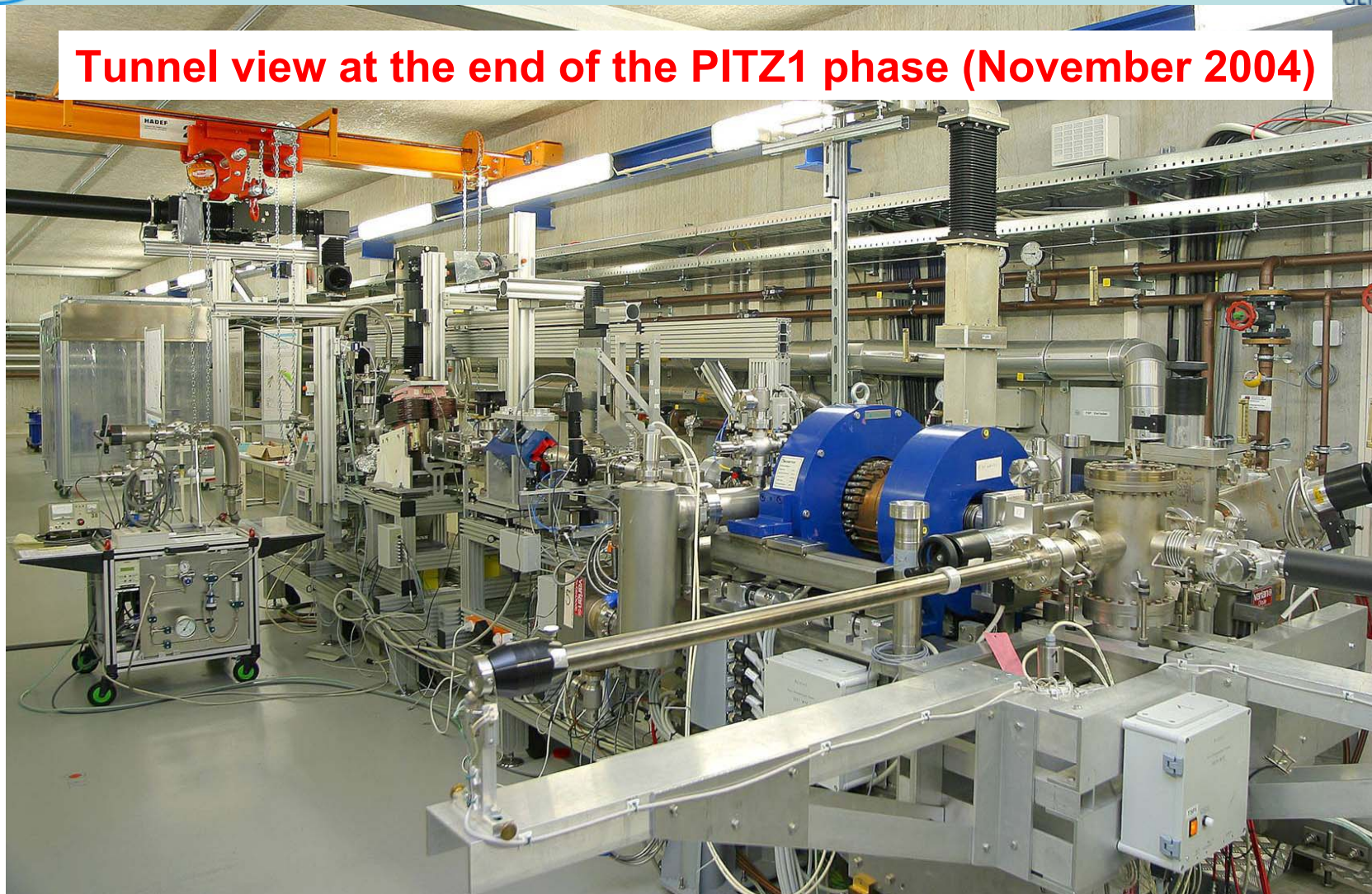
$$\varepsilon_{\#61} = \sqrt{0.01 + 0.05\sqrt{E}}$$

Extrapolation for the XFEL case:

(emittance budget: 0.9 mm mrad)

$$\varepsilon = \frac{\sigma_x}{\sigma_y} \sqrt{A + B\sqrt{E_{field}}} \approx 0.7 \text{ mm mrad}$$

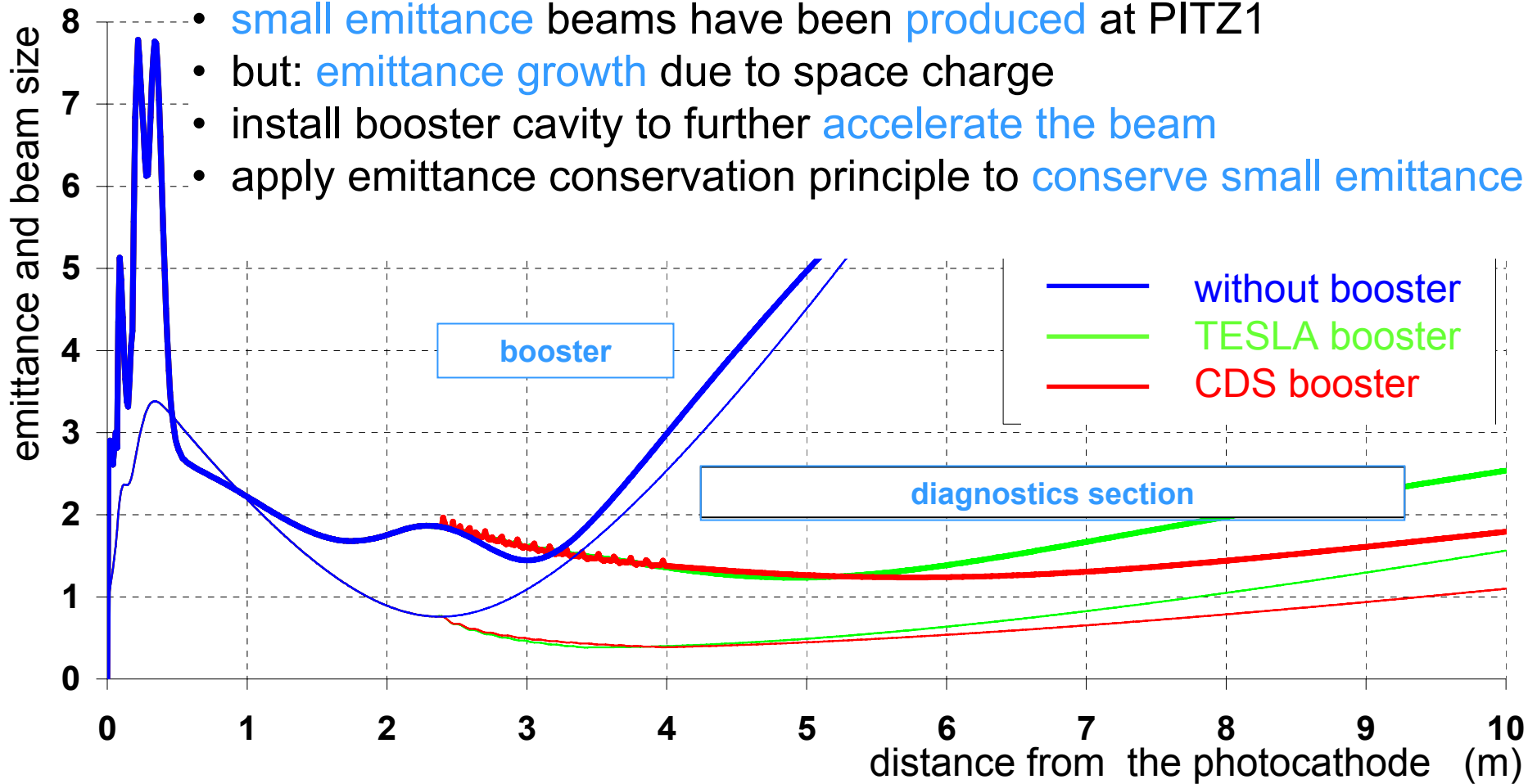
Tunnel view at the end of the PITZ1 phase (November 2004)



Facility upgrade

- Towards PITZ2 -

- small emittance beams have been produced at PITZ1
- but: emittance growth due to space charge
- install booster cavity to further accelerate the beam
- apply emittance conservation principle to conserve small emittance





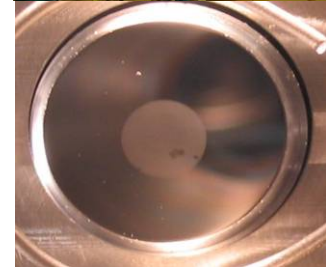
PITZ2 research program



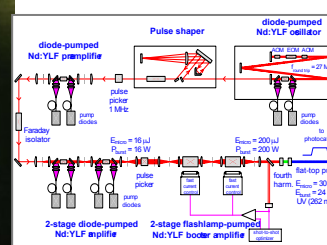
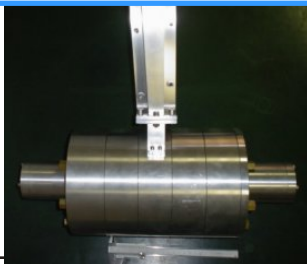
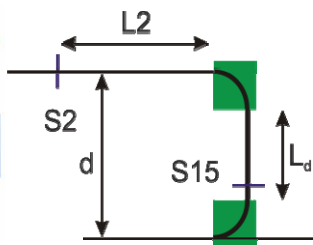
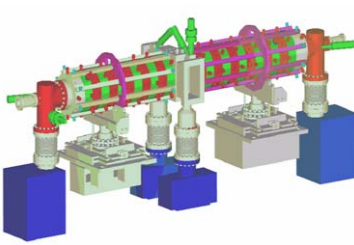
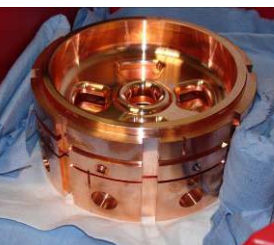
PITZ2 – a large extension of the facility and its research program

- **study the emittance conservation principle:**
install booster and new diagnostics beamline
- **benchmark theoretical understanding of photoinjectors:**
improved simulation tools, detailed comparison simulation vs. measurement
- **reach XFEL requirements (0.9 mm mrad @ 1 nC):**
increase RF field at the cathode, improve laser system and photocathodes
- **study XFEL parameter space:**
low charge, short bunches, higher repetition rates
- **test new developments:**
RF system, gun cavities, diagnostics, cathodes, laser

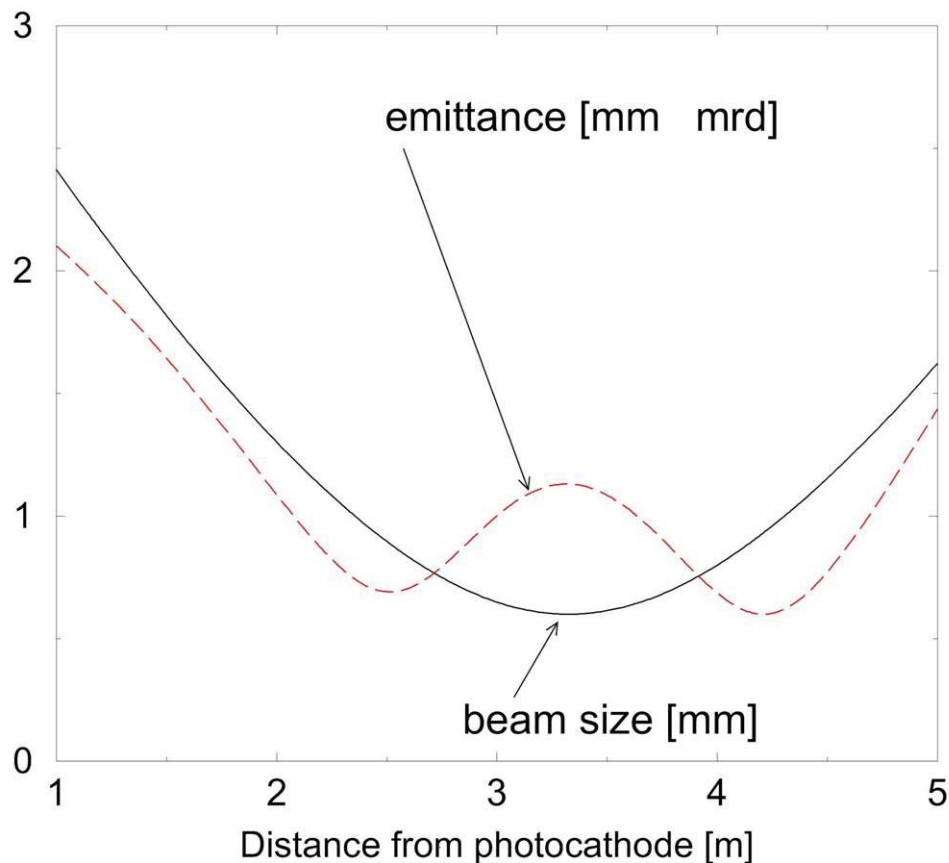
- **BESSY Berlin:** ICTs, magnets, PS, vacuum expert
- **CCLRC Daresbury:** phase space tomography module
- **DESY Hamburg:** new cavities (Gun3, Gun4, CDS booster)
- **INRNE Sofia:** emittance measurement system (EMSY)
- **INR Troitsk:** CDS booster cavity
- **LAL Orsay:** high energy spectrometers
- **LASA Milano:** cathode system
- **LNF Frascati:** RF deflecting cavity
- **MBI Berlin:** laser system
- **TU Darmstadt:** beam dynamics simulations
- **Uni Hamburg:** bunch length measurement
- **YERPHI Yerevan:** accelerator controls



Funding through DESY (BMBF), HGF, EC (IA-SFS, EUROFEL)



Solenoid strength, drift length, and accelerating gradient are defined with the „invariant envelope“ technique:



→ place entrance of booster at local emittance maximum and beam size minimum

→ define accelerating gradient by:

$$\gamma'_{boost} = \frac{2}{\sigma_w} \sqrt{\frac{\hat{I}}{3I_0\gamma}}$$

γ'_{boost} = energy gain booster

σ_w = rms beam size

\hat{I} = peak current

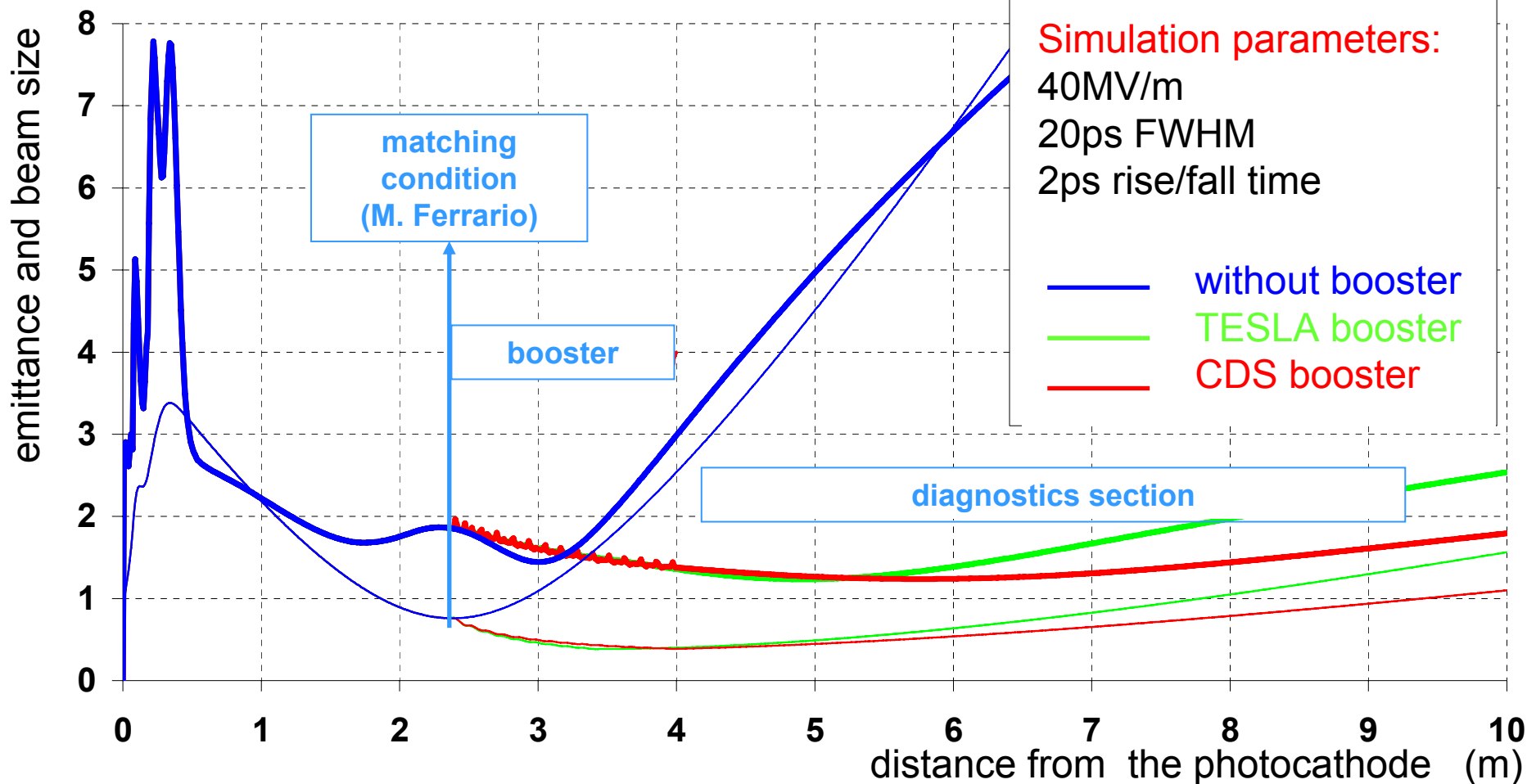
γ = mean beam energy

I_0 = Alfvén current

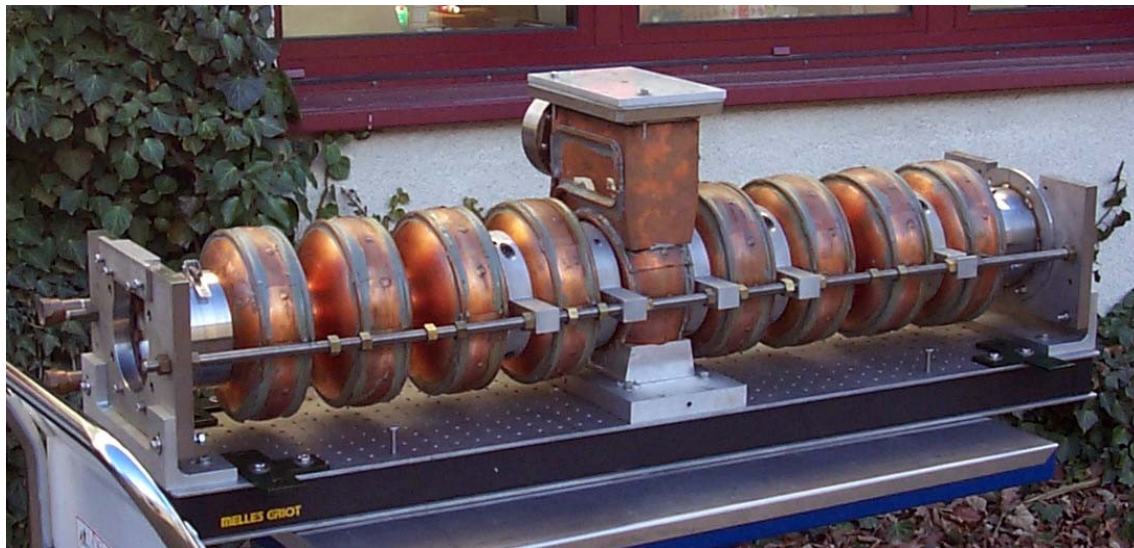
(17 kA for electrons)

The PITZ2 project

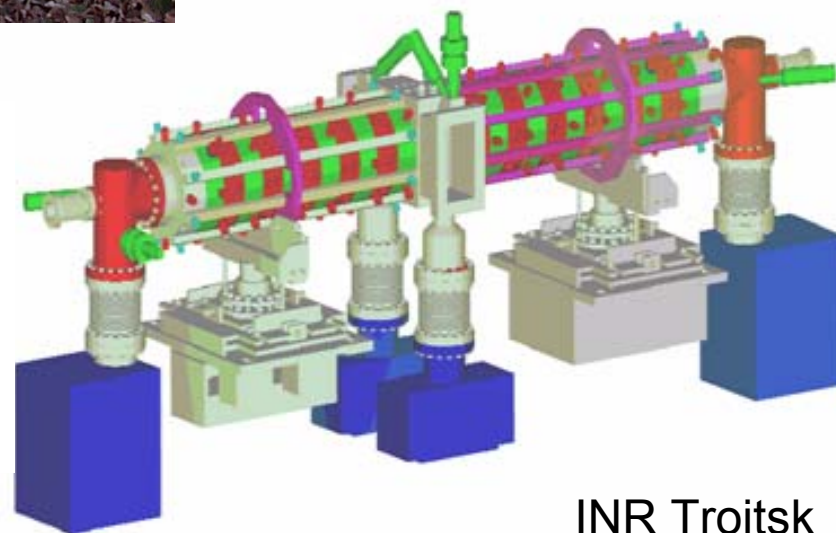
- Simulation of emittance conservation -



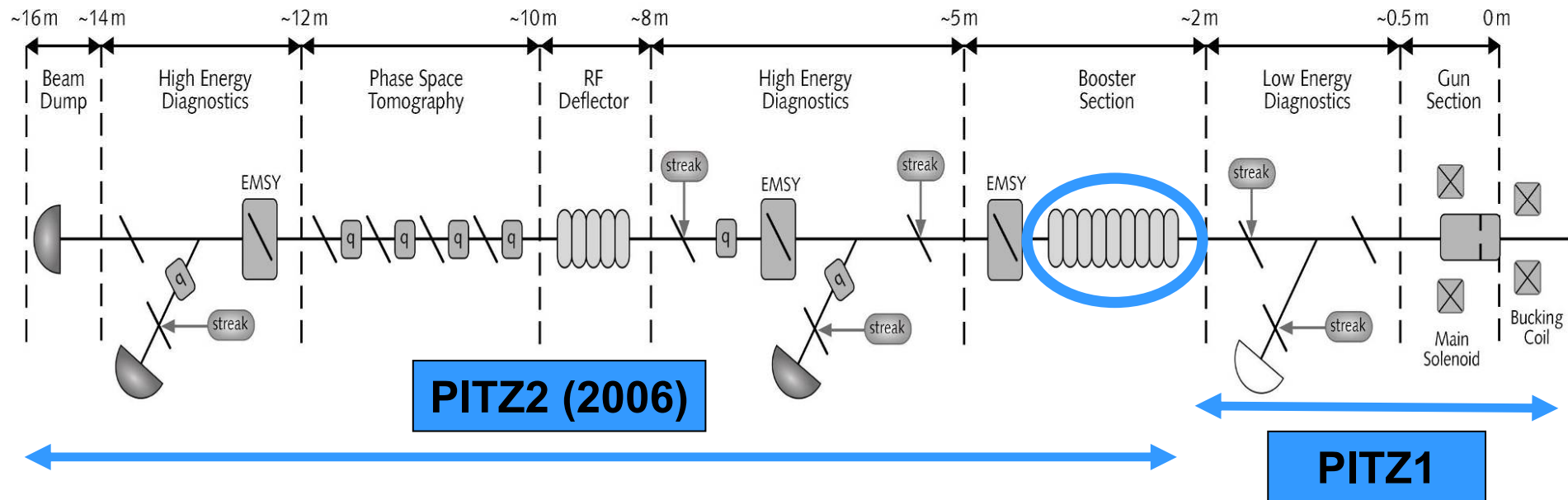
→ check that the principle works and optimize it !



- use a n.c. TESLA prototype cavity as **preliminary booster**
- the **final booster** cavity specially designed for PITZ is in production and will be available in 2007



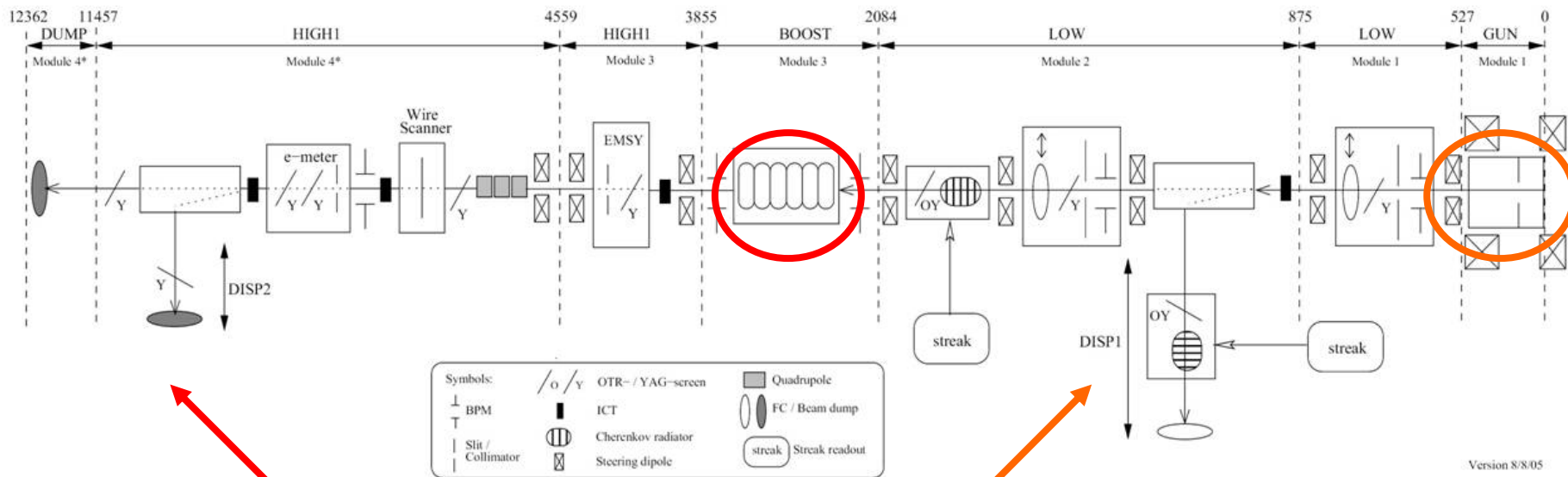
INR Troitsk



For the realization of PITZ2

- upgrade power and cooling systems
- take into operation a 2nd RF system for the booster
- install booster, beam dump, new diagnostics

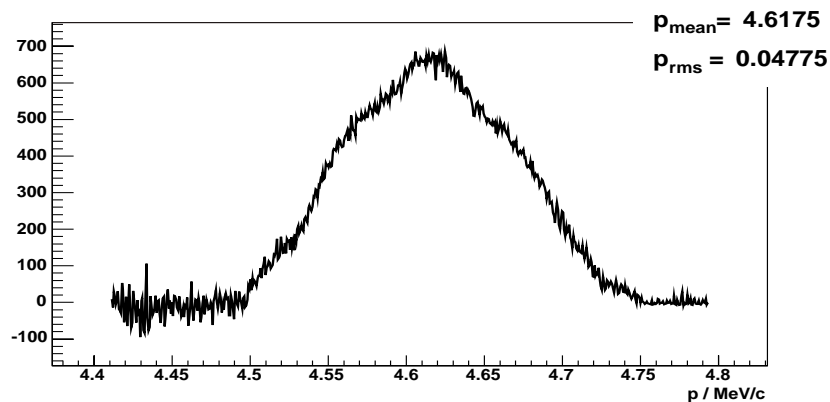
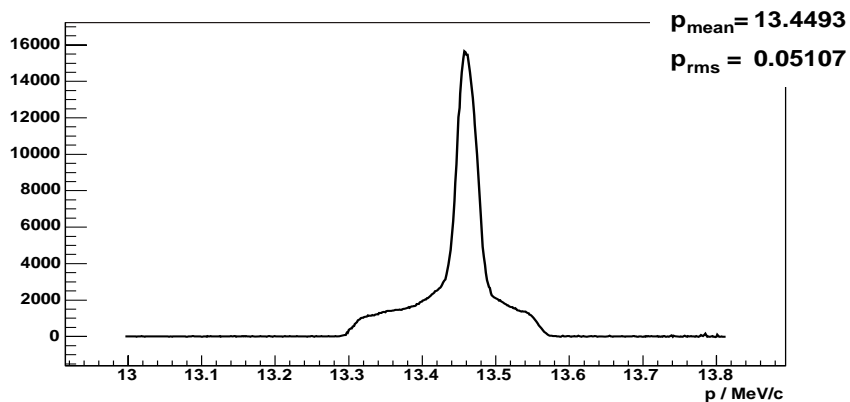
→ start with a minimum version of PITZ2



Version 8/8/05

after the booster: 13.4 MeV

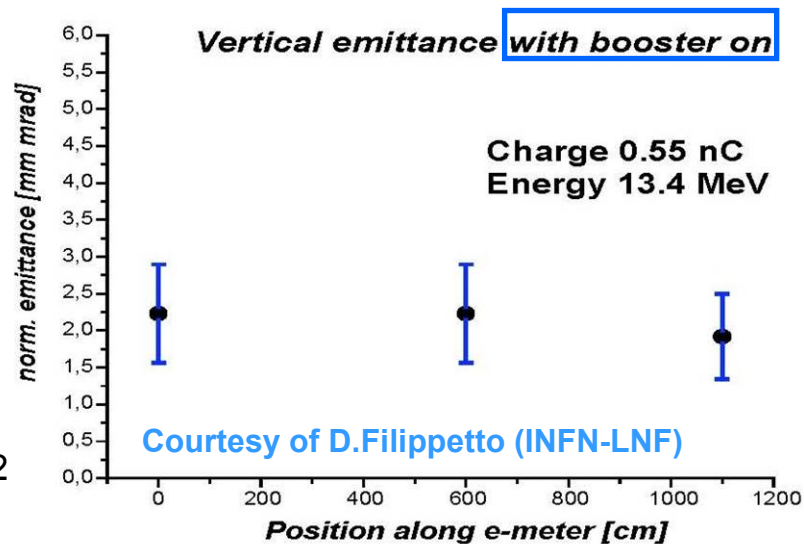
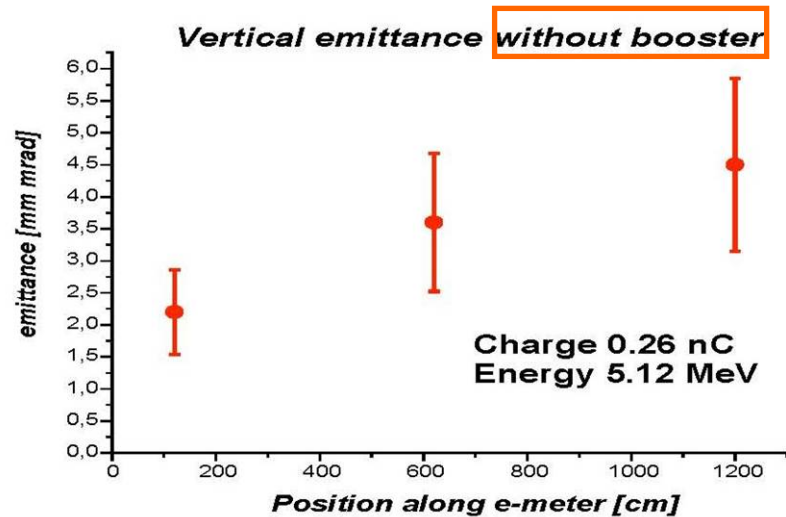
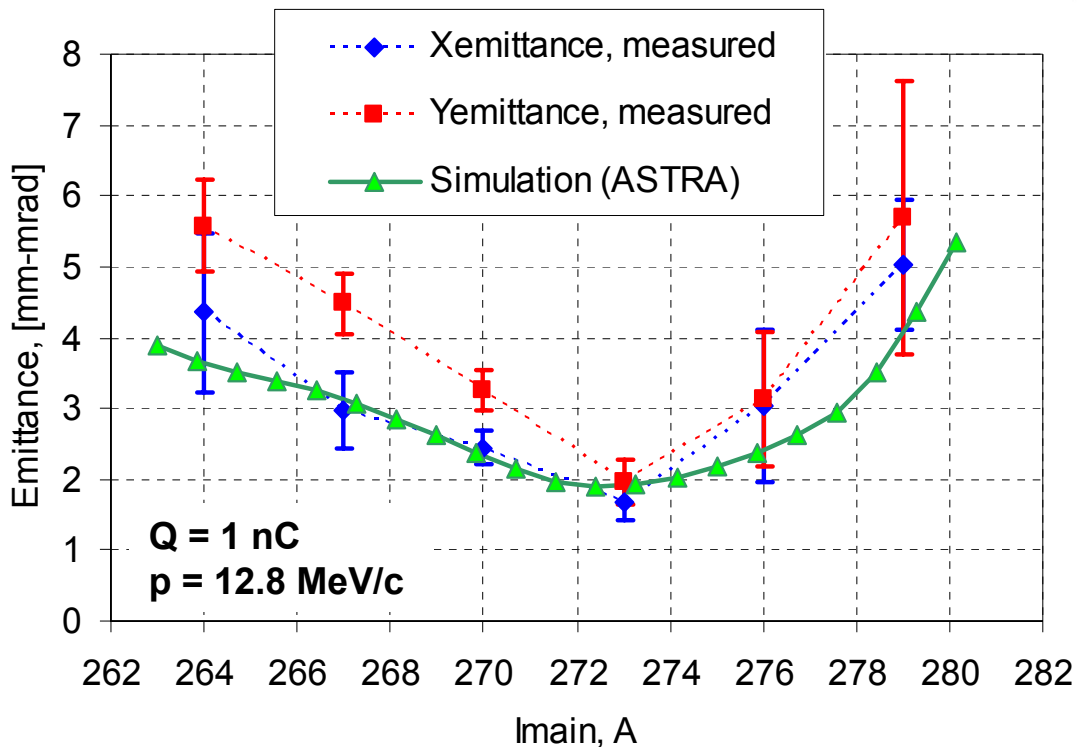
after the gun: 4.6 MeV



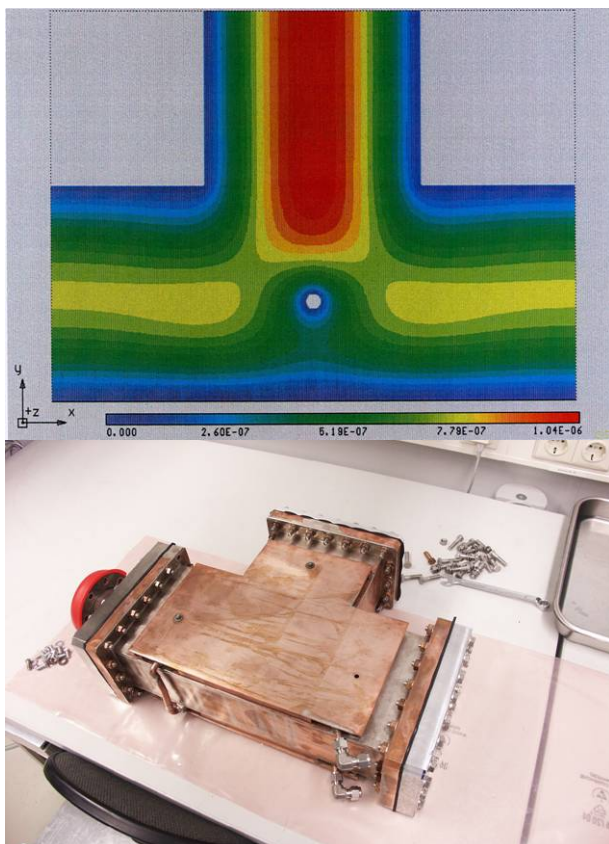
View of the extended PITZ facility (Summer 2005)



- commissioning of new diagnostics
- studies of energy gain in gun and booster
- comparison of emittance measurements with EMSY (PITZ) and e-meter (LNF)



- 10 MW klystron necessary to reach **gradients above 42 MV/m** in the gun
- use **multi beam klystron** from Thales
- RF output via two 5 MW arms → **power combiner** needed

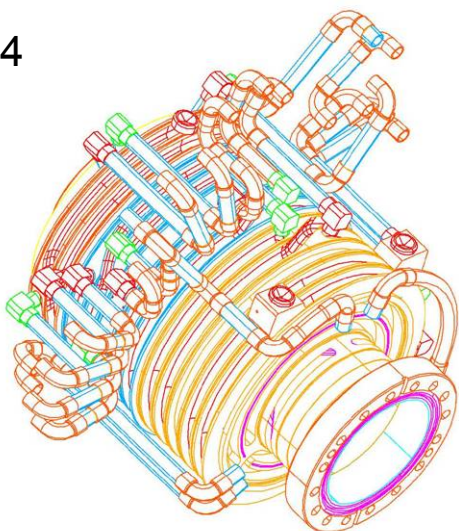


- Gun1 with 10 MW klystron tested up to ~57 MV/m in 2005
- Goal for XFEL: reach 60 MV/m → continue tests in 2006

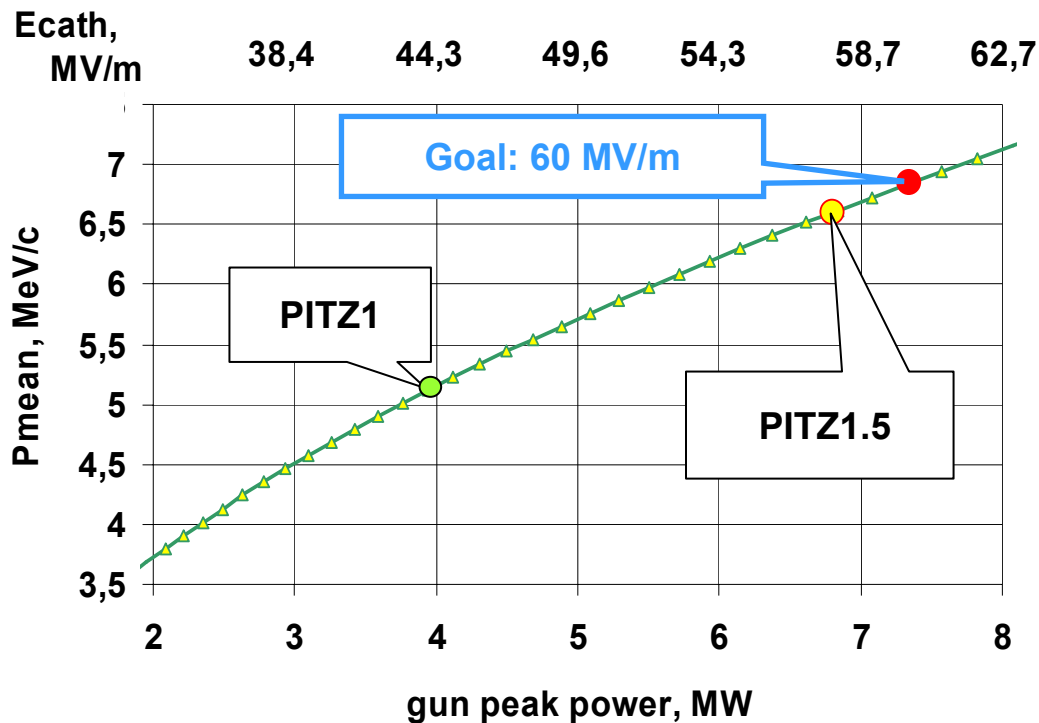
Problem:

thermal load of the gun →
new gun with improved cooling

Gun4



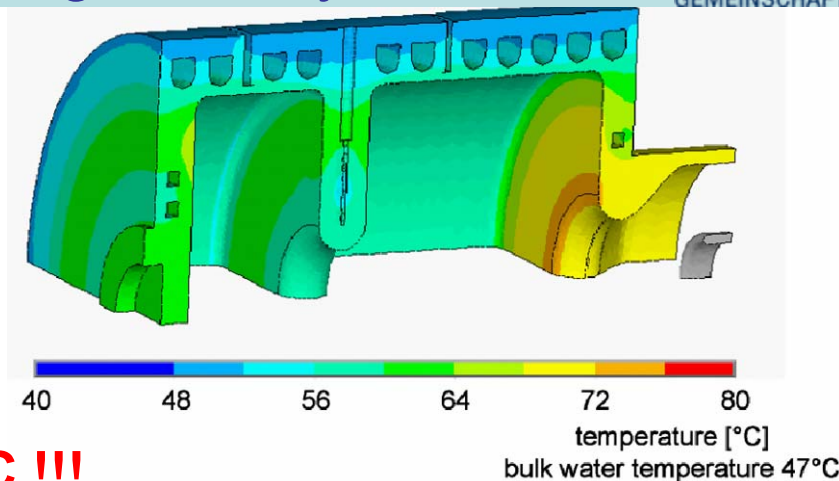
max. mean momentum ↔ gun power



Calculations of thermal load:

- 27 kW of average RF power: $\Rightarrow 80^{\circ}\text{C}$

(40MV/m, 900 μs , 10 Hz) **✓ done**
(PITZ1)

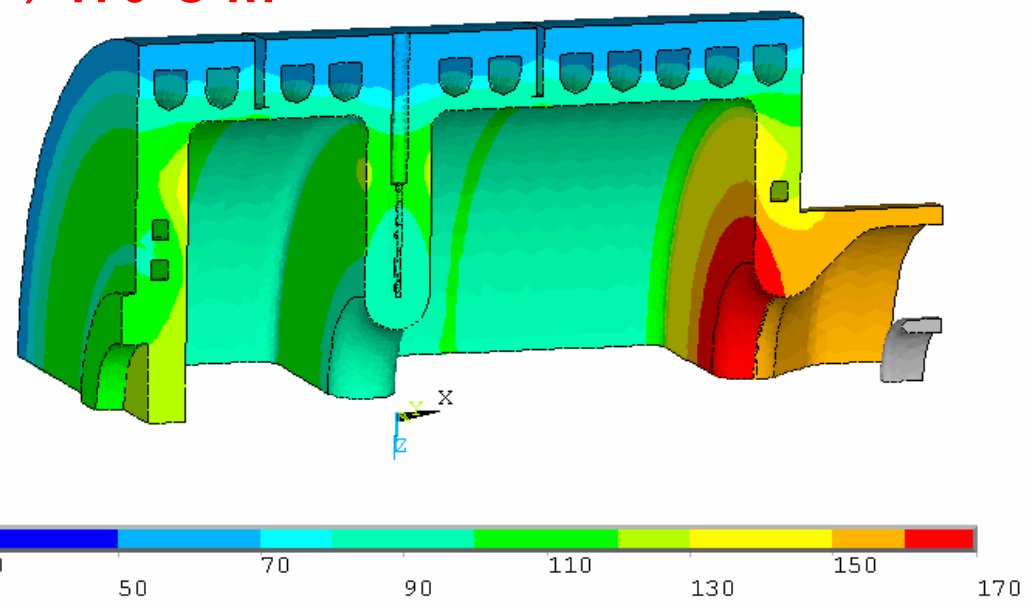


- 130 kW of average RF power: $\Rightarrow 170^{\circ}\text{C}$!!!

(60MV/m, 650 μs , 30 Hz)



- vacuum
- dark current
- new cathodes !!!
- new gun geometry ?



Courtesy of Frank Marhauser (BESSY)



Summary



- sophisticated e^- sources are needed for the operation of FELs
→ RF photo cathode guns
- **PITZ** is a dedicated test facility at DESY in Zeuthen
- **PITZ1** has been successfully finished, and a completely characterized gun has been installed at the VUV-FEL
- the facility upgrade is ongoing, a preliminary booster and first **PITZ2** diagnostics have been taken into operation
- next steps are: study emittance conservation principle and approach the XFEL emittance requirements
- in parallel: do gun power tests and prepare new guns